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18 **Abstract**

19 The interfacial zone between a bulk fluid and a mineral surface is where all exchange
20 of matter and energy occurs during chemical weathering. However, our knowledge is still
21 limited with respect to understanding where and how the rate-determining dissolution
22 reactions take place. A complicating factor is the commonplace formation of amorphous Si-
23 rich surface layers (ASSL), which may hinder contact between the fluid and the mineral
24 surface. To address the role of ASSL, we investigated the dissolution of a common silicate
25 (diopside), and related the bulk dissolution rate with the nanoscale dissolution rate and surface
26 chemistry of its individual prevalent faces. While ASSL were evidenced on all of the
27 investigated faces, only those formed on (110) and ($\bar{1}\bar{1}0$) were passivating, thereby controlling
28 the reactivity of the underlying faces. The (110) and ($\bar{1}\bar{1}0$) faces intersect the highest density
29 of Mg-O-Si and Fe-O-Si bonds, and this specificity may explain the passivating behavior of
30 the corresponding ASSL. Moreover, we evidenced an inverse relation between aqueous silica
31 concentration and the bulk dissolution rate of crushed diopside grains, which suggest that the
32 (110) and ($\bar{1}\bar{1}0$) faces are predominant in a powder. By considering ASSL as a separate phase
33 that can control silicate dissolution rates, extrapolated laboratory-based rates at conditions
34 relevant to the field can be lowered by up to several orders of magnitude, thereby decreasing
35 the large gap between laboratory and natural rates. This has important implications for more
36 accurately modeling chemical weathering reactions, so important today for the C cycle and
37 CO₂ sequestration.

38

39 *Keywords:* dissolution kinetics; chemical weathering; passivation; dissolution anisotropy;
40 fluid/silicate interfaces.

41

42 **1. Introduction**

43 The chemical weathering of silicate materials plays a central role in many major
44 engineering, environmental, and Earth science processes. Whether it determines the rates of
45 denudation and soil formation (Godd ris et al., 2010), CO₂ uptake and its impact on climate
46 change (Le Hir et al., 2008; Beaulieu et al., 2012), hydrothermal circulation (Fritz et al.,
47 2010), durability of radioactive waste confinement glasses (Frugier et al., 2008; Cailleteau et
48 al., 2008) or geological sequestration of CO₂ (Knauss et al., 2005), the same strategy is
49 commonly applied for determining the long term evolution of fluid-rock interactions. This
50 strategy relies on the experimental determination of the influence of a few parameters (mainly
51 pH, temperature (*T*), ionic strength, and concentration of organic ligands) on the dissolution
52 rate of single mineral powders in chemostats, almost always at far-from-equilibrium
53 conditions. The derived kinetic rate laws are subsequently implemented into reactive transport
54 codes (e.g. Knauss et al., 2005; Godd ris et al., 2010). However, the utility of such laws to
55 predict the rates of the abovementioned processes has been questioned for more than 20 years:
56 it is well known that laboratory-based rates can be up to 5 orders of magnitude greater than
57 those measured in the field, casting doubt both on the usefulness of laboratory rates and on
58 the accuracy of reactive transport simulations (White et al., 1996; White and Brantley, 2003;
59 Maher et al., 2004). Despite the emergence of some promising propositions to bridge the gap
60 between laboratory and field measurements (e.g. Nugent et al., 1998; Lasaga and L ttge,
61 2001; Arvidson and L ttge, 2010; Maher, 2010; see detailed discussions in e.g. White and
62 Brantley, 2003; Zhu, 2005), and aside from a limited number of studies which managed to
63 reconcile experimental and field data at specific sites (e.g. Maher et al., 2009), upscaling
64 laboratory results to the field essentially remains an elusive goal.

65 Addressing this challenge requires an in-depth understanding of silicate reactivity and
66 the underlying nm-scale processes. A key parameter arises from the detailed investigation of
67 weathered silicate surfaces. [Hellmann et al. \(2012\)](#) have recently extended more than 40 years
68 of direct and indirect observations (e.g. [Luce et al., 1972](#); [Petit et al. 1987](#)) by demonstrating
69 that regardless of the reaction conditions (fluid composition, T , reaction duration and location
70 (i.e. field or laboratory), mineral chemistry and structure, presence of biota), nm-thick
71 amorphous surface altered layers enriched in silica were generally found to have formed on
72 weathered silicate mineral surfaces (note however that the question as to whether or not the
73 formation of such layers is ubiquitous remains open -see e.g. the work by [Lee et al. \(2008\)](#),
74 which failed to find amorphous layers on weathered feldspars in spite of the use of state-of-
75 the-art microscopic techniques). Therefore, as previously pointed out by e.g., [Jordan et al.](#)
76 [\(1999\)](#) or [Zhu et al. \(2006\)](#), the basic question that needs to be addressed is: which part of the
77 interfacial zone, defined as the chemically and structurally modified entity between the
78 pristine mineral surface and the bulk fluid, ultimately controls the dissolution rate? The two
79 candidates for answering this question are (a) the inner interface, defined as the boundary
80 between the pristine mineral and the amorphous silica-rich surface layer (hereafter referred to
81 as: ASSL), (b) the outer interface, where the bulk fluid contacts the ASSL. If the ASSL are
82 not passivating, the inner interface will control the kinetics, and conversely, if they are
83 passivating (i.e. totally non-permeable), the outer interface hinders access of the bulk fluid to
84 the unaltered mineral surface, and thereby will control the dissolution process. Both cases
85 have been reported for silicate glasses and minerals (e.g. [Jordan et al., 1999](#); [Daval et al.,](#)
86 [2009a, b](#); [Geisler et al., 2010](#); [Hellmann et al., 2012](#) vs. [Daux et al., 1997](#); [Berger et al., 2002](#);
87 [Daval et al., 2011](#)). In addition, the presence of passivating ASSL has not yet been integrated
88 in current reactive transport codes. This has important consequences because it can lead to a
89 dramatic overestimation of dissolution rates, even in simple batch experiments ([Daval et al.,](#)

90 2011). The quantitative recognition of the effects of passivation shows promise as a means for
91 reconciling field and laboratory chemical weathering rates.

92 In the present study, we provide a detailed investigation of the face-specific
93 dissolution of a common silicate mineral (diopside) and combine these results with
94 macroscopic measurements of bulk diopside dissolution rates to shed light on key parameters
95 that render certain ASSL passivating. Quite surprisingly, the results described below show
96 that the passivating properties of ASSL are face-specific. This finding has important
97 consequences on our ability to accurately model the kinetics of fluid-rock interactions, as well
98 as the interpretation of experimental mineral dissolution results determined in the laboratory.

99 2. Materials and methods

100 The present study consists of two independent series of experiments aiming at
101 investigating the effect of $\text{SiO}_2(\text{aq})$ concentrations on diopside dissolution rates (R_{Di}), both on
102 crushed grains at the macro-scale, and on selected faces at the nano-scale. The starting
103 materials are cm-sized gems coming from Mererani (Tanzania), and were previously
104 described in Daval et al. (2010). Based on electron microprobe analyses, the chemical
105 composition of the diopside used in this study has the following composition:
106 $\text{Ca}_{1.01}\text{Mg}_{0.96}\text{Fe}_{0.05}\text{Si}_{1.98}\text{O}_6$, in close agreement with that reported in Daval et al. (2010).

107 2.1 Bulk dissolution experiments on diopside powders in mixed-flow reactors (MFR)

108 Samples were initially crushed, sieved to recover the 300-500 μm -sized fraction, and
109 ultrasonically washed in absolute ethanol following the procedure described in Daval et al.
110 (2010). The measured Kr BET specific surface area was $0.028 \text{ m}^2\cdot\text{g}^{-1}$. The experiments were
111 conducted in a MFR system, using the exact same set-up as in Daval et al. (2010). In this
112 previous study, a rate plateau was evidenced as long as the Gibbs free energy with respect to
113 diopside dissolution ($\Delta G_r(\text{Di})$) was below $-76 \text{ kJ}\cdot\text{mol}^{-1}$. Consequently, to single out the

114 intrinsic effect of $[\text{SiO}_2(\text{aq})]$ only, all experiments of the present study were conducted at
 115 conditions where R_{Di} is $\Delta G_r(\text{Di})$ -independent (for all experiments, $\Delta G_r(\text{Di}) \leq -89 \text{ kJ.mol}^{-1}$).
 116 Consistent with [Daval et al. \(2010\)](#), the experiments were carried out at 90 °C and at 2 MPa
 117 fluid pressure, at $\text{pH}_{(90^\circ\text{C})}$ close to 5 (4.97 ± 0.04). The input solutions contained an acetate pH
 118 buffer (6.4 mM sodium acetate and 5 mM acetic acid; see [Daval et al., 2010](#) for details).

119 If the Si-rich layers which form on diopside are passivating, R_{Di} should exhibit a
 120 strong dependence on $[\text{SiO}_2(\text{aq})]$. Assessing this point was performed by varying the inlet
 121 concentration of $\text{SiO}_2(\text{aq})$ (by adding variable amounts of sodium metasilicate), with all of the
 122 other experimental parameters (sample mass and grain size, flow rate, reaction time, pH)
 123 remaining roughly constant from one run to the other. The pH of the input and output
 124 solutions was measured periodically. The *in situ* pH and saturation indices of the solution
 125 were calculated using the CHESS code ([van der Lee and de Windt, 2002](#)), based on the EQ3/6
 126 database (see [Daval et al., 2010](#) for details). Activity coefficients for aqueous species were
 127 calculated using the Davies equation. The ionic strength of the solutions was between 7 and
 128 11 mmol.l^{-1} . The inlet and outlet concentrations of dissolved cations (Si, Ca, Mg) were
 129 measured by ICP-OES (Varian 720-ES). The steady-state conditions were assumed when the
 130 following two conditions were verified: (1) the length of the run was long enough to ensure
 131 the attainment of a hydrodynamic steady state (based on the injection of a minimum of 2–3
 132 reactor volumes, (2) the concentration of all elements was constant, within experimental
 133 uncertainties. The steady-state concentrations of Ca, Mg (and Si, when possible) were used to
 134 calculate R_{Di} following the classical MFR relation linking concentrations and rates:

$$135 \quad R_{\text{Di},i} = \frac{v \times \Delta[i]}{\eta_i \times \text{SSA} \times m_0} \quad (1)$$

136 where $R_{\text{Di},i}$ ($\text{mol.m}^2.\text{s}^{-1}$) is the dissolution rate of diopside determined with respect to the i^{th}
 137 species of diopside, v is the flow rate (l.s^{-1}), $\Delta[i]$ is the difference between the effluent and
 138 influent concentrations of a solute i (mol.l^{-1}), η_i is the stoichiometric coefficient of element i

139 in the mineral, SSA is the Kr BET specific surface area ($\text{m}^2\cdot\text{g}^{-1}$), and m_0 is the initial mass of
140 diopside (g).

141 2.2 Effect of $[\text{SiO}_2(\text{aq})]$ on R_{Di} as a function of surface orientation

142 The crystallographic orientation of euhedral cm-sized diopside crystals was
143 determined by electron backscatter diffraction (EBSD) using a Zeiss EVO MA10 scanning
144 electron microscope (SEM) (Figs. 1a, b). Because EBSD is a technique sensitive to the first
145 tens of nm of the surface structure, the quality of the diffraction patterns we obtained (e.g.
146 Fig. 1b) ensured that the outermost atomic layers of the diopside surfaces were crystalline
147 prior to the beginning of the experiments. After thorough cleaning in an ethanol ultrasonic
148 bath for ~30 min and rinsing in ultrapure water, selected faces were examined afterwards to
149 determine roughness. Surface roughness at small scales ($80 \times 80 \mu\text{m}$) was measured at a
150 minimum of 5 different areas by atomic force microscopy (AFM) using a Digital Instruments
151 Multimode scanning probe microscope with a Nanoscope IV control system, whereas large
152 scale roughness ($1 \times 3 \text{ mm}$) was determined with a vertical scanning interferometer (VSI;
153 Wyko NT 3300) in stitching mode. Only the most pristine faces (i.e. pit- and coating-free;
154 mean arithmetic roughness (R_a) $\leq 4 \text{ nm}$ for an $80 \times 80 \mu\text{m}$ scan size) were used for running
155 the experiments. When no satisfactory face could be found for a given crystallographic
156 direction, the crystals were cut following calculated angles, polished with a standard protocol
157 using alumina suspensions of decreasing grain sizes and soft polishing cloths; the ultimate
158 step was a final polishing using a colloidal silica suspension. Each crystal was then mounted
159 in a Ti-jig (Fig. 1c). Pressure via a Ti screw was applied to a viton disk, creating a non-
160 wetted, unreacted reference surface. The jigs were subsequently suspended in a Teflon reactor
161 (120 mL) for a month at $90 \text{ }^\circ\text{C}$ (Fig. 1d). Average changes in height measured by VSI
162 between the unreacted reference surface and the reacted mineral surface allowed for the
163 determination of the nanoscale dissolution rate of the specific face following:

164
$$R^{(hkl)} = (\Delta h / t) \times \bar{V}^{-1} \quad (2)$$

165 where $R^{(hkl)}$ ($\text{mol}\cdot\text{m}^{-2}\cdot\text{s}^{-1}$) is the dissolution rate of the (hkl) face, Δh (m) is the surface retreat, t
166 (s) is time, and \bar{V} ($\text{m}^3\cdot\text{mol}^{-1}$) is the molar volume of diopside (Arvidson et al., 2004). In
167 addition, selected areas were scanned weekly *ex situ* by AFM to monitor the evolution of etch
168 pit formation. At pH = 5 the vertical surface retreat was estimated to be too small to be
169 accurately measured by VSI. Consequently, all of the experiments were performed at pH = 1,
170 where the dissolution is much faster (Knauss et al., 1993), either in Si-rich (≥ 2.2 mM) and Si-
171 poor (≤ 0.1 mM) solutions. Strictly speaking, comparing the passivating ability of ASSL of
172 experiments conducted at pH = 5 to others at pH = 1 would require that passivation of
173 diopside surface by ASSL is a pH-independent process. Given that the solubility of any SiO_2
174 polymorph is roughly constant in such a pH range, it was supposed that this was actually the
175 case. Moreover, it is worth mentioning that passivation processes have indeed been reported
176 both in acidic (Daval et al., 2011), circum-neutral (Berger et al., 2002) and slightly alkaline
177 conditions (Daux et al., 1997).

178 After completion of the surface topography measurements, the samples were carbon
179 coated and thin sections perpendicular to the investigated faces were prepared by focused ion
180 beam (FIB) milling. The thickness and chemical composition of the thin sections were then
181 analyzed by transmission electron microscopy (TEM) at 200 kV (FEI Tecnai G²). Energy
182 dispersive X-Ray (EDX) line scans were acquired using an EDAX Si–Li detector with ultra-
183 thin window. Energy filtered TEM chemical images and electron energy loss spectra (EELS)
184 were obtained with a postcolumn Gatan GIF imaging filter, using the Ca $L_{2,3}$, O K , Mg K , and
185 Si K edges.

186 **3. Results and Discussion**

187 *3.1 Dependence of the bulk dissolution rate of diopside on [SiO₂(aq)]*

188 A typical result from mixed-flow reactor (MFR) experiments is shown in Fig. 2a.
189 After achievement of steady-state conditions, the inlet solution was switched from a Si-rich to
190 a Si-free solution. After a sharp increase, the outlet Ca and Mg concentrations leveled to a
191 plateau ~10 times greater than that observed in the Si-rich solution. Given that steady-state
192 conditions were achieved in both cases, and that neither the mass of the powder nor the flow
193 rate were changed between the two experiments, this directly translates into a dissolution rate
194 ~10 times faster in the Si-free solution compared to the Si-rich condition. The dependence of
195 the diopside dissolution rates on [SiO₂(aq)] was found to be independent of the order in which
196 the experiments were done (i.e. switch from Si-rich to Si-free, or vice versa). Overall, an
197 inverse linear relation was found between the bulk R_{Di} and total [SiO₂(aq)] (Fig. 2b, see Table 1
198 for details). Based on the data obtained by [Daval et al. \(2010\)](#), R_{Di} did not depend on the
199 $\Delta G_r(\text{Di})$ under our experimental conditions ($\Delta G_r(\text{Di}) \leq -89 \text{ kJ}\cdot\text{mol}^{-1}$ for all experiments, see
200 details in section 2.1), so that it can be confidently concluded that the observed decrease in
201 R_{Di} was a function of [SiO₂(aq)], and not $\Delta G_r(\text{Di})$.

202 These results suggest that diopside crystals are apparently homogeneously covered
203 with a very thin passivating ASSL. Our interpretation is based on the argument that at
204 conditions where amorphous silica is soluble (i.e. where the bulk fluid is undersaturated with
205 respect to amorphous silica), any thin passivating layer that forms is intrinsically unstable,
206 resulting in its subsequent dissolution, which supposedly occurs nearly synchronously with
207 the re-exposure of the pristine diopside surface. The diopside will then dissolve and release
208 Si, which in turn results in a new thin (possibly a few atomic monolayers), passivating
209 (unstable) ASSL forming. This cycle of auto-passivation is consistent with the observation

210 that (1) the faster the dissolution rate of the passivating silica layer (R_{ASSL}), the faster the
 211 concomitant dissolution of diopside (R_{Di}) and (2) because R_{ASSL} depends on the bulk Gibbs
 212 free energy for the dissolution of the surface layer ($\Delta G_r(ASSL)$), R_{Di} will depend on
 213 $[SiO_2(aq)]$.

214 The above process can be expressed mathematically in the following manner, where
 215 R_{Di} is equivalent to the far-from-equilibrium rate of dissolution of the passivating layer ($R_{-\infty}$),
 216 modified by a chemical affinity term ($f(\Delta G_r(ASSL))$):

$$217 \quad R_{Di} \Leftrightarrow R_{ASSL} = R_{-\infty} \cdot f(\Delta G_r(ASSL)) \quad (3)$$

218 The chemical affinity term, incorporating $\Delta G_r(ASSL)$, can take many forms, depending on
 219 the assumed mechanism. Consistent with the linear trend we found (Fig. 2b), we chose to use
 220 a simple relation based on transition state theory (Lasaga, 1981):

$$221 \quad f(\Delta G_r(ASSL)) = 1 - \exp\left(\frac{\Delta G_r(ASSL)}{RT}\right) \quad (4)$$

222 If one supposes that $a_{SiO_2(aq)}$ is equivalent to $[SiO_2(aq)]$, after re-arrangement, the combination
 223 of Eqs. (3) and (4) leads to:

$$224 \quad R_{Di} \equiv R_{-\infty} - \frac{R_{-\infty}}{K_s} [SiO_2(aq)] \quad (5)$$

225 Thus, in Fig. 2b, the solubility constant of the ASSL (K_s) can be approximated by the
 226 intercept of the regression line of $R_{Di} = f([SiO_2(aq)])$ with the x axis, yielding a value of $K_s =$
 227 $10^{-2.66}$. Although our data can be successfully fitted with a rate equation like Eq. (5), whether
 228 an equilibrium can be strictly defined for such a system in a bulk thermodynamic sense is
 229 subject to question, and further experimental and theoretical research is required to validate
 230 such a conceptual framework. Supposing that an equilibrium can be defined, and for the
 231 purpose of comparison, the ASSL would be slightly more soluble than α -cristobalite
 232 ($K_s^{T=90^\circ C}(\alpha\text{-cristobalite}) = 10^{-2.73}$) and less soluble than pure, anhydrous amorphous silica

233 ($K_s^{T=90^\circ\text{C}}(\text{SiO}_2(\text{am})) = 10^{-2.23}$), according to the EQ3/6 thermodynamic database. Moreover, the
234 intercept of the regression line of $R_{Di} = f([\text{SiO}_2(\text{aq})])$ with the y axis yields $R_{Di} = 9.09 \times 10^{-10}$
235 $\text{mol.m}^{-2}.\text{s}^{-1}$, in excellent agreement with the dissolution rate plateau reported in [Daval et al.,](#)
236 [2010](#) ($R_{Di} = 8.76 \times 10^{-10} \text{ mol.m}^{-2}.\text{s}^{-1}$). Finally, it can be verified that the data of [Daval et al.](#)
237 [\(2010\)](#) obtained at various $\text{SiO}_2(\text{aq})$ concentrations (Fig. 2b, white squares) is in reasonable
238 agreement with relation (5). The scatter of the data is likely to be due to the fact that in this
239 previous study, $[\text{SiO}_2(\text{aq})]$ was not the only parameter varying from one experiment to the
240 other, because that study's goal was to investigate the effect of stoichiometric saturation state
241 with respect to diopside ($\Delta G_r(\text{Di})$) on R_{Di} . Therefore, in addition to $[\text{SiO}_2(\text{aq})]$, other
242 parameters may have affected R_{Di} during the course of some of these previous experiments.

243 To conclude, the results from the present study suggest that at a macro-scale, the
244 rate-limiting process for diopside dissolution occurs at the outer (bulk fluid/ASSL) interface,
245 due to the impermeable nature of the passivating ASSL that prevents the bulk fluid from
246 reaching the pristine diopside surface. In the following sections, the links between the macro-
247 scale observations and the micro- to nano-scale measurements of diopside dissolution are
248 developed.

249 3.2 Face-specific dissolution rate of diopside in low- $[\text{SiO}_2(\text{aq})]$ solutions

250 According to [Dana \(1899\)](#), 85 natural forms have been observed for diopside.
251 However, because diopside is an inosilicate (Q^2 structure) with silicate chains parallel to the c
252 axis, euhedral crystals are often elongated in this direction, so that the most prevalent faces
253 are those parallel to the c axis, in particular: (100); (010); (110) and $(\bar{1}\bar{1}0)$. To a lesser extent,
254 the faces (001), (111), $(\bar{1}01)$, and more rarely (021), are also encountered. Below we report on
255 the microscopic dissolution features and rates of 6 of these common faces: (100), (010),
256 (110), $(\bar{1}\bar{1}0)$, (001), and (021).

257 *3.2.1 Surface retreat measurements*

258 The surface retreat measured by VSI for each face is listed in Table 2, and the
259 corresponding dissolution rates (referred to as $R_{\text{low-Si}}^{(hkl)}$) are reported in Table 3. As an example,
260 a typical topographic image of the reacted (001) face is shown in Fig. 3. The non-wetted
261 (masked) surface is revealed by the presence of a raised flat circular area. This reference area
262 contrasts with the adjacent dissolved surface that is thoroughly pitted and has a mean
263 elevation $\sim 5.1 \mu\text{m}$ lower than the reference level. On the whole, the $(hk0)$ faces are much less
264 reactive than the $(hkl \neq 0)$ faces. The face-specific dissolution rates $R_{\text{low-Si}}^{(hkl)}$ observe the
265 following trend: $R_{\text{low-Si}}^{(001)} > R_{\text{low-Si}}^{(021)} \gg R_{\text{low-Si}}^{(110)} \approx R_{\text{low-Si}}^{(\bar{1}\bar{1}0)} \approx R_{\text{low-Si}}^{\text{MFR}} > R_{\text{low-Si}}^{(010)} > R_{\text{low-Si}}^{(100)}$, with $R_{\text{low-Si}}^{\text{MFR}}$ being
266 the extrapolated rate from the results of MFR experiments performed on diopside powders
267 reported in [Knauss et al. \(1993\)](#).

268 The differences in the face-specific dissolution rates can in part be explained in terms
269 of the crystallographic bonding structure. In the diopside structure, silica tetrahedral units are
270 organized as single chains parallel to the c -axis, where each tetrahedron is connected to two
271 others. The dissolution rates will differ for different faces as a function of the number of Si-O-
272 Si bonds that must be broken per tetrahedron. As an example, the retreat of $(hk0)$ faces
273 requires the breaking of two Si-O-Si bonds to liberate one Si tetrahedron, whereas the retreat
274 of (001) and (021) faces requires the breaking of only one Si-O-Si bond per Si tetrahedron
275 (Fig. 4). Thus, the dissolution rates of the specific faces fall into two classes:
276 $R^{(001),(021)} \gg R^{(hk0)}$. While previously inferred for phyllosilicates (e.g. [Turpault and Trotignon,](#)
277 [1994](#)), these results are, to the best of our knowledge, the first direct face-specific
278 measurements that confirm that the connectedness of Si tetrahedrons impacts the dissolution
279 rate of specific crystal faces.

280 *3.2.2 Etch pit formation*

281 The better lateral resolution of AFM compared to that of VSI allowed for a more
 282 detailed investigation of the dissolved surface topographies. A common feature of the pits
 283 observed on all faces is that their sloping sides merge with pointed bottoms (Fig. EA1 in
 284 Electronic Annex), a typical feature of pits arising from dislocation defects in minerals (Dove
 285 et al., 2005 and references therein). Whereas the pits formed on (hkl) faces are elongated
 286 following the c axis and relatively small ($\sim 10 \times 3 \mu\text{m}$), those formed on the (001) and (021)
 287 faces are significantly larger ($> 30 \times 70 \mu\text{m}$) and rounded. The most pitted faces are (110)
 288 and $(\bar{1}\bar{1}0)$, and to a lesser extent, (001). With the notable exception of the (021) face, the pit-
 289 volume density ($PVD_{\text{low-Si}}^{(hkl)}$, defined as the volume of pits per diopside unit area) on a given
 290 face is correlated with its corresponding dissolution rate (see Fig. EA1 in Electronic Annex;
 291 $PVD_{\text{low-Si}}^{(001)} > PVD_{\text{low-Si}}^{(110)} \approx PVD_{\text{low-Si}}^{(\bar{1}\bar{1}0)} > PVD_{\text{low-Si}}^{(021)} \gg PVD_{\text{low-Si}}^{(100)} \geq PVD_{\text{low-Si}}^{(010)}$).

292 Dislocations in general (e.g. Lasaga and Blum, 1986; Lee and Parsons, 1997), and
 293 screw dislocations in particular (e.g. Lasaga and Lüttge, 2001; Dove et al., 2005; Beig and
 294 Lüttge, 2006; Arvidson and Lüttge, 2010), have been proposed as a major driving force for
 295 mineral dissolution processes. Recently, Amiguet et al. (2010) reported that the most common
 296 Burgers vectors for diopside dislocations were by far $\frac{1}{2} \langle 110 \rangle$ and [001]. Given that the
 297 corresponding screw dislocations outcrop at the surfaces of faces (110) and (001),
 298 respectively, this explains why the most pitted faces are faces (110), $(\bar{1}\bar{1}0)$, and (001). Because
 299 faces (110) and $(\bar{1}\bar{1}0)$ are structurally identical, their reactivities should be identical. This has,
 300 in fact, been confirmed in this study, since the values of $R_{\text{low-Si}}^{(hkl)}$, $PVD_{\text{low-Si}}^{(hkl)}$, and $d_{\text{low-Si}}^{(hkl)}$
 301 (thickness of the ASSL, see below) are very similar for these faces. Moreover, faces (110)
 302 and $(\bar{1}\bar{1}0)$ dissolve faster than faces (010) and (100). This result may strengthen the relation
 303 between screw dislocations, etch pit density, and rates proposed in previous studies (e.g.
 304 Arvidson and Lüttge, 2010). In conclusion, our results support the idea that face-specific

305 dissolution rates are primarily a function of two parameters, namely silica tetrahedron
306 connectedness and dislocation density. The former parameter appears, however, to be the
307 more important one since $R_{\text{low-Si}}^{(021)} \gg R_{\text{low-Si}}^{(110)} \approx R_{\text{low-Si}}^{(\bar{1}\bar{1}0)}$, although $PVD_{\text{low-Si}}^{(110)} \approx PVD_{\text{low-Si}}^{(\bar{1}\bar{1}0)} > PVD_{\text{low-Si}}^{(021)}$.

308 3.2.3 Surface altered layer formation

309 Previous investigations of fluid-diopside interfaces have revealed the presence of nm-
310 thick, amorphous Si-rich surface layers (ASSL) (e.g. [Petit et al., 1987](#); [Eggleston et al., 1989](#);
311 [Hellmann et al., 2012](#)). Our TEM results show that their thickness ($d_{\text{low-Si}}^{(hkl)}$) is face-dependent.
312 As a first approximation, $d_{\text{low-Si}}^{(hkl)}$ is correlated with the absolute dissolution rate of each face
313 ($d_{\text{low-Si}}^{(001)} \approx d_{\text{low-Si}}^{(021)} \gg d_{\text{low-Si}}^{(010)} \approx d_{\text{low-Si}}^{(110)} \geq d_{\text{low-Si}}^{(\bar{1}\bar{1}0)} > d_{\text{low-Si}}^{(100)}$; see Table 3). Interestingly, there could be
314 up to 2 orders of magnitude between the thickest and thinnest layers, which may be an
315 additional explanation why some previous studies failed to find unambiguous evidence for
316 ASSL formation (see discussion in [Hellmann et al., 2012](#)).

317 Energy filtered TEM and TEM-EDX revealed that the ASSL are depleted in Ca and
318 Mg, and composed almost exclusively of SiO₂. For the thickest layers (> 10 nm), the chemical
319 gradients (e.g. Ca) at the inner interface are very sharp, on the order of a few nm (Fig. 5a).
320 Whereas broad cation depletion profiles would have resulted from a mechanism controlled by
321 solid-state volume interdiffusion ([Hellmann et al., 2003](#)), indeed, our observations indirectly
322 support the premise that the relatively thicker ASSL (>10 nm) are permeable, allowing
323 unhindered aqueous transport between the pristine mineral surface and the bulk fluid.
324 Consistent with a growing number of studies, the observation that the release of cations is not
325 transport-limited by solid-state diffusion is in better agreement with a mechanism whereby the
326 ASSL formed by interfacial dissolution-precipitation (e.g. [Teng et al., 2001](#); [Hellmann et al.,](#)
327 [2003](#); [Daval et al., 2009b](#); [Zhang and Lüttge, 2009](#); [King et al., 2011](#); [Hellmann et al., 2012](#);
328 [Ruiz-Agudo et al., 2012](#)). In regard to the much thinner ASSL (<10 nm) formed on (*h**k*0)

329 faces, the measurement of chemical gradients proved to be analytically challenging by TEM,
330 such that we could not make any inferences regarding their transport properties. To address
331 this question, additional experiments were run using solutions with elevated $[\text{SiO}_2(\text{aq})]$,
332 followed by VSI measurements of face-specific dissolution rates.

333 *3.3 Face-specific dissolution rates of diopside in elevated $[\text{SiO}_2(\text{aq})]$ solutions*

334 Based on the results of the macro-scale experiments, the approximate solubility of
335 the ASSL that presumably passivate diopside is close to $10^{-2.66}$ M. Consequently, the
336 experiments reported below were run with silica-rich input solutions ($[\text{SiO}_2(\text{aq})] = 2.2$ mM).
337 Such conditions stabilized the passivating ASSL (in other words, because the bulk fluid is
338 close to saturation with respect to the ASSL, they should no longer have a tendency to
339 dissolve). The dissolution rates ($R_{\text{hi-Si}}^{(hkl)}$) calculated from the measured surface retreats (Table
340 2), are reported in Table 3. Quite unexpectedly, the only faces dramatically affected by high
341 silica concentrations were (110) and $(\bar{1}\bar{1}0)$ (Figs 6a, c and Table 3). However, to make sure
342 that the surface retreats were not underestimated for these two faces, we measured the
343 thicknesses of the ASSL by TEM. Actually, in case the layers are non-passivating
344 (permeable), stabilizing the outer interface results in the subsequent growth of the layers (see
345 e.g. [Daval et al., 2009a, b](#); [King et al., 2011](#)), so that the measurement of surface retreat could
346 only result in misleading conclusions (in other words, we can no longer make the
347 approximation that the measured change in height between the reference surface and the
348 ASSL (Δh) is equivalent to the change in height between the reference surface and the reacted
349 diopside surface located beneath the ASSL). We found that $d_{\text{hi-Si}}^{(110)} \approx d_{\text{hi-Si}}^{(\bar{1}\bar{1}0)} \leq 10$ nm (Fig. EA2
350 in Electronic Annex), a result which is similar to what we observed in the low- $[\text{SiO}_2(\text{aq})]$
351 experiments. Thus, the striking differences in surface retreats is a real phenomenon. These
352 differences of reactivity were accompanied by changes in surface etch pitting: while deep (~

353 400 nm) triangular pits formed on faces (110) and ($\bar{1}\bar{1}0$) in low-[SiO₂(aq)] solutions (Fig. 7a),
354 shallow pits (~ 50 nm) orientated without any obvious crystallographic direction (Fig. 7b)
355 tended to form when the surfaces were reacted in elevated [SiO₂(aq)] solutions. On the other
356 hand, AFM investigations did not reveal any obvious changes in etch pit morphology, depth,
357 and density for the other four faces as function of high and low [SiO₂(aq)].

358 Taken together, these results unexpectedly provide evidence that passivating ASSL
359 uniquely formed on faces (110) and ($\bar{1}\bar{1}0$). These results give rise to the following three points
360 of discussion:

361 (1) Why does the macroscopic reactivity of diopside grains seem to be controlled
362 largely by the (110) and ($\bar{1}\bar{1}0$) faces?

363 Point number one would suggest that the total surface area of the crushed diopside
364 was mainly comprised of (110) and ($\bar{1}\bar{1}0$) planes. In fact, the (110) surface is the dominant
365 cleavage plane of diopside (Dana, 1899). It is thus likely that grains resulting from grinding
366 express mainly (110), ($\bar{1}\bar{1}0$), and equivalent planes (Fig. EA3 in Electronic Annex). In
367 addition, the mean $R_{\text{low-Si}}^{\text{MFR}}$ values are about one order of magnitude lower than $R_{\text{low-Si}}^{(001)}$ (see
368 Table 3). This result confirms that the contribution of highly reactive faces such as (001) or
369 (021) to the total surface area of the grains must be minor.

370 (2) Why do we still observe an important surface retreat of faces (010), (001), (021)
371 (and possibly, (100)) when the experiments are initiated in elevated [SiO₂(aq)] solutions,
372 whereas the ASSL are supposedly thermodynamically stable?

373 Indeed, if the ASSL formed on e.g. the (021) faces are both permeable (as suggested
374 in Section 3.2.3) and stable, the measured surface retreat should be small, and the thickness of
375 the ASSL should be on the order of a few microns. Conversely, stable passivating ASSL
376 should be evidenced by small surface retreats and thin layers (as observed for (110) and ($\bar{1}\bar{1}0$))

377 faces). These two scenarios do not correspond to our measurements. Therefore, the
378 observation that the surface retreats did not change between Si-low and Si-rich solutions (at
379 least for (010), (001), (021) faces) ultimately indicates that the ASSL formed on such faces
380 are not stable, so that they keep dissolving. Hence, the solubility of ASSL is not the same for
381 all faces, which indirectly supports the idea that the structure and/or chemistry of ASSL
382 formed on e.g. (001) and (021) diverge from those formed on (110) and ($\bar{1}\bar{1}0$) faces.

383 (3) Perhaps the most fundamental question evoked by this study is: why do
384 passivating ASSL develop only on faces (110) and ($\bar{1}\bar{1}0$) ?

385 While our study was aimed at deciphering whether the rate-limiting reactions of
386 diopside dissolution occur at (a) the outer (bulk fluid/ASSL) or (b) inner (ASSL/pristine
387 diopside) interface, our results suggest that the answer is neither “(a) nor (b)”, but rather “(a)
388 and (b)”, as the location of the rate-limiting reactions strongly rely on the bonding structure of
389 diopside. As further developed in Section 3.4, passivation processes are crucial for
390 extrapolating laboratory-based dissolution rates because the driving force of the reaction is
391 different when a surface is passivated or not (in the former case, the effect of the chemical
392 affinity on steady-state dissolution rate has to be defined with respect to the ASSL, whereas in
393 the latter case, it has to be defined with respect to the silicate).

394 Interestingly, Figure 4a reveals that the (110) and ($\bar{1}\bar{1}0$) faces are the only ones which
395 exclusively intersect Si-O-Mg bonds (or Si-O-Fe, since Fe and Mg share the same
396 crystallographic site). We speculate that this local environment favors the formation of an
397 ASSL which incorporates large amounts of Fe and/or Mg, a specificity which may lead to (or
398 accelerate the rate of formation of) an amorphous silica structure that is passivating.
399 Supporting this argument is the observation that ASSL formed on olivine (an orthosilicate
400 exclusively composed of Si-O-Mg and Si-O-Fe bonds) are passivating as well (Daval et al.,
401 2011), whereas they are not passivating when formed on the (Mg, Fe)-free inosilicate

402 wollastonite (Daval et al., 2009a, b). The identification of the molecular-scale mechanisms
403 responsible for minor elements modifying the transport properties and/or structure of
404 amorphous silica requires additional research, and based on our current knowledge, any
405 propositions should therefore be considered as speculative. One possible explanation that
406 could account for our observations is that the molar volume of the (Mg, Fe)-bearing ASSL
407 may be greater than that of the parent phase. The positive difference of molar volumes
408 between ASSL and the silicate mineral would lead then to the formation of a protective layer,
409 as generally described, for instance, in Velbel (1993). In any case, although the detailed
410 mechanisms accounting for a specific role for certain cations in modifying the structure
411 and/or molar volume of the ASSL is unclear, we note that their effect on the transport
412 properties of ASSL has been already evidenced in previous studies (e.g. Iler, 1979; Morris
413 and Fletcher, 1987; Cailleteau, et al., 2008). As an example, the incorporation of Zr is thought
414 to be responsible for maintaining an open porous structure in silica layers (Cailleteau, et al.,
415 2008), whereas minor amounts of Fe may favor the formation of impermeable Si-rich phases
416 (Morris and Fletcher, 1987), which would support the results in the present study. On the
417 other hand, King et al. (2011) did not evidence any passivating process during the course of
418 olivine silicification experiments, which would seem to contradict the above-mentioned
419 mechanism. While this observation points out that a detailed understanding of passivation
420 processes deserves more work, one possible explanation could be that their experiments were
421 conducted in high ionic strength media ($> 2M$), resulting in the presumable complexation of
422 Fe and Mg in the solution, such that less Fe and Mg were available for modifying the ASSL
423 structure.

424 *3.4 Why does passivation matter? Bridging the gap between field and laboratory rates*

425 Beyond being an important issue in the field of materials sciences and geochemistry,
426 characterizing fluid/solid interfaces and understanding which part of the interfacial zone

427 (inner vs. outer interface) plays the major role in the rate-limiting process during dissolution
428 of silicate minerals has major implications for our ability to correctly use laboratory data to
429 model the rates of chemical weathering reactions in the field. In the vast majority of past and
430 present experimental studies, silicate dissolution rates ($R_{silicate}$) are determined under so-called
431 “far-from-equilibrium” conditions, where dissolved silica concentrations are low, and
432 therefore do not influence $R_{silicate}$. Moreover, all of the geochemical codes that we are aware
433 of do not integrate the presence of ASSL, which potentially should be treated as individual,
434 separate phases, whose solubility may control the dissolution rate of the underlying silicate
435 minerals. In general, geochemical codes treat the chemical saturation of the bulk fluid in
436 terms of the following formalism:

$$437 \quad R_{silicate} = R_{-\infty} \cdot f(\Delta G_r(\text{silicate})) \quad (6)$$

438 where:

$$439 \quad f(\Delta G_r(\text{silicate})) = 1 - \exp\left(\frac{\Delta G_r(\text{silicate})}{RT}\right) \quad (7)$$

440 In Eq. (6), the measured far-from-equilibrium rates ($R_{-\infty}$) are adjusted to conditions closer-
441 to-equilibrium with the chemical affinity function given by (7), which is a function of the
442 Gibbs free energy for silicate mineral dissolution reaction ($\Delta G_r(\text{silicate})$). Conceptually, this
443 relation implies that ASSL do not exist, or that they are so porous that their presence does not
444 matter, such that the rate-limiting step(s) occur(s) at the silicate/water interface. Very
445 importantly, the present study demonstrates that this assumption is not always correct, and
446 that for specific cases (discussed below), rate laws in the form of Eq. (3) should be considered
447 for more accurately modeling the effect of fluid composition on silicate dissolution rates, as
448 has already been proposed for silicate glasses ([Grambow and Muller, 2001](#)). Failure to
449 account for the effects of passivating ASSL may result in a significant overestimation of
450 dissolution rates. Given that laboratory dissolution rates generally are orders of magnitude

451 higher than their natural counterparts (White et al., 1996; White and Brantley, 2003; Maher et
452 al., 2004), it is worth assessing whether or not passivation is an (additional) likely mechanism
453 for bridging the gap between laboratory and field rates. The geological relevance of this
454 proposition will rely on both (1) rock and (2) fluid compositions encountered in the field:

455 (1) Based on the results in the present study, we suggest that chemical weathering
456 reactions of rocks that contain large amounts of (Mg, Fe)-rich silicates, such as (ultra)basic
457 rocks and basalts, are potentially affected by passivation. Interestingly, it is estimated that up
458 35% of the CO₂ consumed by continental silicate alteration is attributed to basalts, making
459 these rocks important actors of chemical weathering (Dessert et al., 2003) and the C cycle.
460 Knowledge that a strong coupling exists between physical and chemical erosion (Gaillardet et
461 al., 1999), it is likely that in active weathering terrains, minerals are primarily broken up
462 following dominant cleavage directions. Thus, the reactivity of pyroxenes in the field
463 probably mimics that of the diopside grains investigated in this study (Fig. 2b), similar to the
464 cases of olivine (Daval et al., 2011) and basaltic glass (Daux et al., 1997).

465 (2) With respect to aqueous fluids, one could consider the chemical composition of
466 rivers as a potential, “average” integrated model for the various environments encountered in
467 the field. The chemical compositions of rivers draining either basaltic environments (where
468 pyroxenes are common rock-forming minerals) or other continental environments are taken
469 into account below. Considering [SiO₂(aq)] in rivers as a proxy for chemical weathering and
470 CO₂ consumption (Gaillardet et al., 1999), an interesting observation is that SiO₂(aq) ranges
471 over a wide range of concentrations, from a few tens of μM to several hundreds of μM
472 (Gaillardet, et al., 1999; Louvat and Allègre, 1997, 1998; Louvat et al., 2008). Considering a
473 simple estimation, one can use the chemical composition of rivers to calculate the
474 corresponding ΔG_r values with respect to diopside and to a passivating ASSL, assuming that
475 its solubility is close to that of cristobalite (see Section 3.1). Obviously, such a value may

476 vary with the chemical composition of the ASSL (see discussion in Section 3.3), but from the
477 results of the present study, ASSL with solubility close cristobalite are passivating, whereas
478 ASSL with higher solubility (e.g. those formed on (001) and (021) faces) are permeable. It is
479 noteworthy that aside from a few exceptions, all of the reported rivers are largely
480 undersaturated with respect to diopside, whereas they are rather close to saturation with
481 respect to cristobalite (Fig. 8a). The effect of such ΔG_r values on the dissolution rates of
482 silicates like diopside, following either relation (4) or (7), is represented in Fig. 8b. For most
483 of the considered rivers, the chemical conditions are such that using relation (7) instead of (4)
484 would result in an overestimation of dissolution rates by one or more orders of magnitude. For
485 one third of the reported rivers, the waters are even slightly oversaturated with respect to
486 cristobalite, implying conditions of stability (i.e. dissolution rates ~ 0) for any passivating
487 ASSL present on diopside, or other mafic minerals and/or glasses.

488 Such simple calculations illustrate how passivation matters in the context of chemical
489 weathering. Passivation is also important for current topics like CO₂ sequestration and related
490 carbonation processes of mafic silicates. As an example, at conditions relevant to CO₂
491 sequestration (e.g. $T \leq 90^\circ\text{C}$), it can be easily calculated that in closed systems, the dissolution
492 of minerals typical of basalts (e.g. olivine, pyroxenes) results in the attainment of saturation
493 with respect to SiO₂ polymorphs, even including highly soluble pure amorphous silica, prior
494 to that of (Ca, Mg) carbonates. The formation of passivating ASSL would result in a
495 difference of several orders of magnitude between the predicted and measured extents of
496 carbonation, as has been experimentally shown for olivine recently (Daval et al., 2011). Such
497 unexpected effects must be taken into account to better assess whether mineral carbonation is
498 a viable process for sequestering anthropogenic CO₂.

499 **4. Conclusions**

500 By investigating diopside dissolution from the nano- to the macro-scale, our study
501 provides new insights on how bulk silicate reactivity is related to complex face-specific
502 behavior at the nanoscale. In conjunction with knowledge of the diopside crystal structure,
503 certain key parameters dictating the transport properties of surface layers were presumably
504 identified, thereby linking our nano- and macro-scale measurements. In particular, we show
505 how nm-thick Si-rich layers (ASSL) sandwiched in between the bulk fluid and the pristine
506 mineral surface may ultimately control silicate reactivity. This has important consequences
507 because it provides additional directions for bridging the gap between laboratory and field
508 measurements. This study has also demonstrated that deriving dissolution mechanisms and
509 rate laws from bulk, macroscopic experiments without a detailed knowledge of the interfacial
510 processes is not without risks. Instead, the deciphering of the interplay of nano- and macro-
511 scale phenomena is likely to represent the future direction of experimental fluid-mineral
512 interaction studies. In addition, the next step forward should be to investigate the transport
513 properties of ASSL formed on feldspars, which represent by far the most abundant group of
514 minerals in the continental crust. Interestingly, the few published studies that indirectly
515 addressed the question as to whether or not ASSL formed on feldspars are porous and
516 permeable enough for not impeding fluid access to the pristine surface of the underlying
517 crystal led to opposite conclusions (e.g. compare the conclusions of Jordan et al. (1999) on
518 anorthite and Hellmann et al. (2003) on labradorite to those obtained by Berger al. (2002) on
519 sanidine). Supposing that ASSL are commonplace in natural geological systems (e.g. Zhu et
520 al., 2006; Hellmann et al., 2012), the abovementioned discrepancies emphasize the need for
521 further detailed studies on the transport properties of ASSL formed on feldspar surfaces under
522 diverse physical and chemical conditions.

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680 **Figure legends**

681 **Fig. 1.** Face-specific diopside dissolution experiments. (a) The first steps consisted in
682 identifying the crystallographic orientation of selected diopside faces by EBSD based on (b)
683 the indexation of diffraction patterns. (c) After initial surface roughness measurements by
684 AFM and VSI (necessitating potential re-polishing of the samples), the crystals were mounted
685 on a Ti-jig. Pressure via a Ti screw was applied to a viton disk (effective diameter: 1.44 mm),
686 creating a non-wetted reference surface. (d) The jig was suspended in a Teflon reactor for a
687 month.

688 **Fig. 2.** Diopside dissolution rate measured in a MFR using 300-500 μm grain-sized powders.
689 (a) Measured concentrations of Ca (circles) and Mg (triangles) released as a function of time.

690 After 18 days, the inlet solution was changed, from $[\text{SiO}_2(\text{aq})] = 2.09 \text{ mM}$ to $[\text{SiO}_2(\text{aq})] = 38$
691 μM , all other parameters being kept constant. This resulted in a substantial increase of Ca and
692 Mg release. (b) Steady-state diopside dissolution rates (blue diamonds) plotted as a function
693 of total $[\text{SiO}_2(\text{aq})]$, showing an inverse linear relation. For comparison, the data of [Daval et al.](#)
694 [\(2010\)](#) are reported as well (white squares). Note that only their data for which $\Delta[i] > 0$ (and
695 thus $R_{\text{Di}} > 0$) are reported, and that this dataset was not used for computing the linear
696 regression depicted in this figure –see text for additional details.

697

698 **Fig. 3.** 3D-view of face (001) reacted at 90°C and $\text{pH} = 1$ for one month in a silica-free
699 solution. The reference area, where the mask was during the experiment, is $5.1 \mu\text{m}$ above the
700 level of the dissolved surface, which appears to be heavily pitted. 3D-view realized by
701 stitching VSI images on an area of $1.9 \times 1.3 \text{ mm}$.

702

703 **Fig. 4.** Projections of diopside structure following (a) [001] and (b) [100] zone axes. The
704 silicate tetrahedrons are blue; calcium, magnesium and oxygen atoms are white, green, and
705 red spheres, respectively. Among the investigated faces, (001) and (021) are the only planes
706 that intersect only one Si-O-Si bond per silicate tetrahedron. Conversely, dissolution normal
707 to $(hk0)$ faces will intersect two Si-O-Si bonds per tetrahedron. Cleavage planes (110) and
708 $(\bar{1}\bar{1}0)$ intersect Si-O-Mg (or Si-O-Fe) bonds only.

709

710 **Fig. 5.** TEM images of fluid/diopside interfaces realized on FIB thin sections perpendicular to
711 (a) (021) and (b) (110) faces after chemical weathering in Si-free solutions. For both cases, an
712 amorphous Si-rich surface layer (ASSL) is evidenced, with thicknesses of $\sim 103 \text{ nm}$ for the
713 (021) face and $\sim 4\text{--}9 \text{ nm}$ for the (110) face (red arrows). For both FIB thin sections, a $\sim 100\text{--}$
714 nm thick carbon (C) coating and a platinum layer were deposited to protect the underlying

715 surfaces during ion beam milling. The insert in Fig. 5a shows a typical EFTEM calcium
716 profile across ASSL formed on the (021) face. It reveals a sharp nm-scale chemical
717 concentration jump between the Ca-depleted ASSL and the pristine diopside. Note that an
718 HRTEM image of the diopside/ASSL contact is provided in the Electronic Annex (Fig. EA4).
719

720 **Fig. 6.** VSI-measured surface dissolution of 4 different crystal reacted for one month in (a, b)
721 Si-free and (c, d) Si-rich solutions, exposing faces (a, c) (110) and (b, d) (001). The reference
722 (masked) surface is located at $z \sim 0$. In Si-free solutions, the ($hk0$) faces were much less
723 reactive than the (001) and (021) faces (i.e. compare retreat of (a) face (110) with (b) (001)).
724 Note that the (001) face was hardly affected by high concentrations of $\text{SiO}_2(\text{aq})$, whereas the
725 dissolution of (110) decreased by ~ 1 order of magnitude. For comparison, far-from-
726 equilibrium bulk dissolution rates from powders (Knauss et al., 1993) would be equivalent to
727 a mean retreat of $\Delta h_{\text{low-Si}} = 614$ nm.
728

729 **Fig. 7.** Representative AFM images of two different crystals rinsed beforehand in ultrapure
730 water, and exposing faces ($\bar{1}\bar{1}0$) after 15 days of alteration in (a) Si-free and (b) Si-rich
731 solutions. The plots on the right hand side of the figures represent topographic profiles from
732 left to right along the corresponding white lines. Well-defined, deep triangular pits formed on
733 the surface of the ($\bar{1}\bar{1}0$) face of diopside in the Si-free solution; pitting was more irregular in
734 the Si-rich solution, with depths < 50 nm. Note that the measured thickness of the ASSL
735 formed on the faces ($\bar{1}\bar{1}0$) during the course of each experiment never exceeded 10 nm (see
736 text and Table 3), such that their formation does not prevent observation of etch pit formation
737 on these faces.
738

739 **Fig. 8.** Plots showing the potential importance of passivation phenomena in terms of bridging
740 the gap between laboratory and field weathering rates. The chemical compositions of rivers
741 draining either basaltic environments (Iceland (triangles), Azores (squares), and Réunion
742 (circles)) or other continental silicates (diamonds) were used to calculate the Gibbs free
743 energy of diopside ($\Delta G_r(\text{Di})$) and cristobalite ($\Delta G_r(\text{Cr})$) dissolutions, using CHESSE. Figure
744 8a shows that almost all rivers are very undersaturated with respect to diopside ($\Delta G_r(\text{Di}) \ll$
745 0), whereas they are close to saturation or even supersaturated with respect to cristobalite
746 (Cr), whose solubility was taken as a possible analog for that of ASSL formed on faces (110)
747 and $(\bar{1}\bar{1}0)$ of diopside. (b) Consequences of this from a kinetic standpoint. The effect of fluid
748 composition is translated through the values of the $f(\Delta G_r)$ functions, considering either
749 $\Delta G_r(\text{Di})$ (x axis) (Eq. 7) or $\Delta G_r(\text{Cr})$ (y axis) (Eq. 4). The dashed line represents a 1:1 relation
750 between $f(\Delta G_r(\text{Di}))$ and $f(\Delta G_r(\text{Cr}))$. Nearly all data points fall below this line, in particular
751 for basaltic environments. Therefore, implementing the $f(\Delta G_r(\text{Cr}))$ function into geochemical
752 codes, in agreement with passivation process, has the potential to lower the laboratory-based
753 rates by several orders of magnitude. The insert in Fig. 8b is a close-up of the area circled in
754 blue. Chemical compositions of the main rivers taken from Louvat and Allègre (1997) for
755 Réunion, Louvat and Allègre (1998) for Azores, Louvat et al. (2008) for Iceland, and
756 Gaillardet et al. (1999) for other environments, considering only the rivers for which silicates
757 contribute more than 20% of the total dissolved load in the river (see Gaillardet et al. (1999)
758 for details).

Table 1. Summary of experimental and calculated data concerning the dissolution of diopside in MFR.

Expt.	time	m_0	v	$[\text{Si}]_{\text{in}}$	$[\text{Ca}]_{\text{out}}$	$[\text{Mg}]_{\text{out}}$	$[\text{Si}]_{\text{out}}$	$\text{pH}_{(20^\circ\text{C})}^{\text{in}}$	$\text{pH}_{(20^\circ\text{C})}^{\text{out}}$	$\text{pH}_{\text{in situ}}^{\text{a}}$	$\text{pH}_{\text{in situ}}^{\text{b}}$	r_{Ca}	r_{Mg}	r_{Si}	r_{Avg}	ΔG_r^{a}	ΔG_r^{b}	$r_{\text{Avg}}(\text{pH} = 5)$
DPS-M	16	0.3212	1.6E-06	6.33	5.52	5.40	16.3	4.84	4.84	4.98	4.98	9.72E-10	1.00E-09	8.97E-10	9.57E-10	-117.9	-117.9	9.49E-10
DPS-O	21	0.6627	6.7E-07	121	21.6	18.5	160	4.82	4.86	4.98	5.01	7.68E-10	6.92E-10	7.11E-10	7.24E-10	-96.4	-95.6	7.24E-10
DPS-P	20	0.2859	6.3E-07	17.8	11.8	11.1	37.2	4.83	4.85	4.97	5.00	9.15E-10	9.05E-10	7.71E-10	8.64E-10	-108.6	-108.0	8.60E-10
DPS-Q	16	0.4393	6.7E-07	115	15.5	14.7	147	4.82	4.86	4.98	5.00	8.32E-10	8.30E-10	8.80E-10	8.47E-10	-98.7	-97.9	8.44E-10
DPS-R	14	0.2859	6.7E-07	768	6.8	6.3	776	4.83	4.82	4.98	4.96	5.61E-10	5.47E-10	3.38E-10	5.54E-10	-93.7	-94.1	5.47E-10
DPS-S	18	0.4938	6.3E-07	1473	6.6	6.1	1480	4.83	4.85	4.98	4.99	3.00E-10	2.90E-10	1.63E-10	2.95E-10	-90.2	-89.8	2.93E-10
DPS-T	15	0.4938	5.8E-07	121	19.9	19.7	164	4.82	4.82	4.98	4.96	8.31E-10	8.66E-10	9.14E-10	8.71E-10	-96.3	-96.7	8.60E-10
DPS-U	14	0.4924	5.8E-07	436	18.4	18.3	473	4.79	4.79	4.95	4.94	7.71E-10	8.07E-10	7.95E-10	7.91E-10	-91.3	-91.5	7.74E-10
DPS-V	19	0.4981	6.3E-07	2090	1.43	1.45	2024	4.84	4.85	4.98	4.99	6.43E-11	6.86E-11	-1.52E-09	6.64E-11	-97.2	-96.9	6.62E-11
DPS-W	14	0.4981	8.7E-07	7.00	15.2	15.3	38.4	4.76	4.81	4.91	4.96	9.35E-10	9.90E-10	9.90E-10	9.72E-10	-108.3	-107.2	9.48E-10

Columns 1-4 indicate: name of the experiment, total duration time (days), initial mass of diopside (grams), flow rate of the pump ($\text{L}\cdot\text{s}^{-1}$). The input ($[\text{Si}]_{\text{in}}$) and output ($[\text{Ca}]_{\text{out}}$, $[\text{Mg}]_{\text{out}}$ and $[\text{Si}]_{\text{out}}$) solution compositions are indicated in the next four columns (μM) (at the beginning of the experiment, $[\text{Ca}]_{\text{in}} = [\text{Mg}]_{\text{in}} = 0$). The pH of the input and output solutions measured at room temperature are reported in the columns labelled $\text{pH}_{(20^\circ\text{C})}^{\text{in}}$ and $\text{pH}_{(20^\circ\text{C})}^{\text{out}}$. These values were used to calculate the *in situ* pH based either (a) on the initial pH and the effluent concentration of species or ($\text{pH}_{\text{in situ}}^{\text{a}}$) (b) on the outlet pH measured at 20°C ($\text{pH}_{\text{in situ}}^{\text{b}}$). The dissolution rates based on each major constituting element of diopside, as well as the unweighted average of the dissolution rate are reported in the subsequent column ($\text{mol}\cdot\text{m}^2\cdot\text{s}^{-1}$) (note: this average rate does not include the values of r_{Si} if $|1 - [\text{Si}]_{\text{in}} / [\text{Si}]_{\text{out}}| \leq 0.05$, which is the analytical limit). The two ΔG columns indicate ΔG_r values ($\text{kJ}\cdot\text{mol}^{-1}$) with respect to diopside dissolution at which the steady-state dissolution rates were measured, based either on $\text{pH}_{\text{in situ}}^{\text{a}}$ or on $\text{pH}_{\text{in situ}}^{\text{b}}$. The final column corresponds to r_{Avg} recalculated for an exact pH of 5.00, adjusted from r_{Avg} , based on the pH-dependence of diopside dissolution given in [Knauss et al., 1993](#). Note that the experiments DPS-R, DPS-T and DPS-W represent the continuation of experiments DPS-P, DPS-S, and DPS-V respectively. The only parameter that was changed between these couples of experiments was the composition of the inlet solution (column 4).

1
2**Table 2. Summary of the surface retreat measurements performed on 12 different crystals.**

Face	$\Delta h_{\text{low-Si}}$ [nm]	t [d]	$\Delta h_{\text{hi-Si}}$ [nm]	t [d]
(100)	160	30.21	96	30.50
(010)	416	30.62	373	29.30
(001)	5070	27.83	4593	27.55
(110)	624	29.70	45	32.14
($\bar{1}\bar{1}0$)	464	27.97	60	30.16
(021)	3625	27.97	3973	31.02

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The orientation of the face analyzed for each crystal is indicated in column 1. The results of experiments performed in Si-free solutions are listed in columns 2 and 3, those from experiments performed in Si-rich solutions in columns 4 and 5. The differences in elevation (= surface retreat) between the masked and unmasked areas ($\Delta h_{\text{low-Si}}$ and $\Delta h_{\text{hi-Si}}$) are reported in columns 2 and 4, with the corresponding time durations of the experiments in columns 3 and 5, respectively.

Table 3. Summary of the face-specific dissolution rates of diopside and measurement of the thickness of ASSL formed in Si-free solution.

Face	$R_{\text{low-Si}}^{(hkl)}$ [mol/m ² /s]	$R_{\text{hi-Si}}^{(hkl)}$ [mol/m ² /s]	$\frac{R_{\text{hi-Si}}^{(hkl)}}{R_{\text{low-Si}}^{(hkl)}}$	$\frac{R_{\text{low-Si}}^{(hkl)}}{R_{\text{low-Si}}^{\text{MFR}}}$	$d_{\text{low-Si}}^{(hkl)}$ [nm]
(100)	9.30E-10	5.53E-10	0.59*	0.26	≤ 1
(010)	2.39E-09	2.24E-09	0.94	0.66	9-15
(001)	3.20E-08	2.93E-08	0.92	8.90	98
(110)	3.69E-09	2.46E-10	0.07	1.03	4-9
($\bar{1}\bar{1}$ 0)	2.91E-09	3.49E-10	0.12	0.81	1-5
(021)	2.28E-08	2.25E-08	0.99	6.33	103

The orientation of the face analyzed for each of the 12 crystals is indicated in column 1. The dissolution rates for each face, either in Si-free (column 2) or in Si-rich (column 3) solution, were calculated following Eq. (2). Column 4 represents the normalization of the face-specific rates obtained in Si-rich solutions to those obtained far from equilibrium, in Si-free solutions. Column 5 is the normalization of the far-from-equilibrium face-specific dissolution rates to that of a diopside powder (extrapolated from far-from-equilibrium MFR experiments reported in [Knauss et al., 1993](#)). Column 6 is the thickness of the ASSL formed on each face for the experiments run in Si-free solutions.

*Given that corresponding measured profiles reported in Table 2 vary by ± 30 nm, the question as to whether or not the face (100) is affected by high aqueous silica concentrations remains an open question.

Figure 1

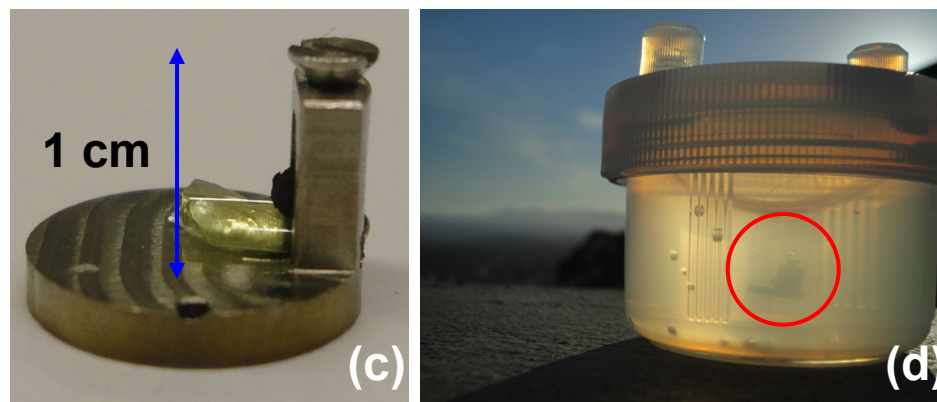
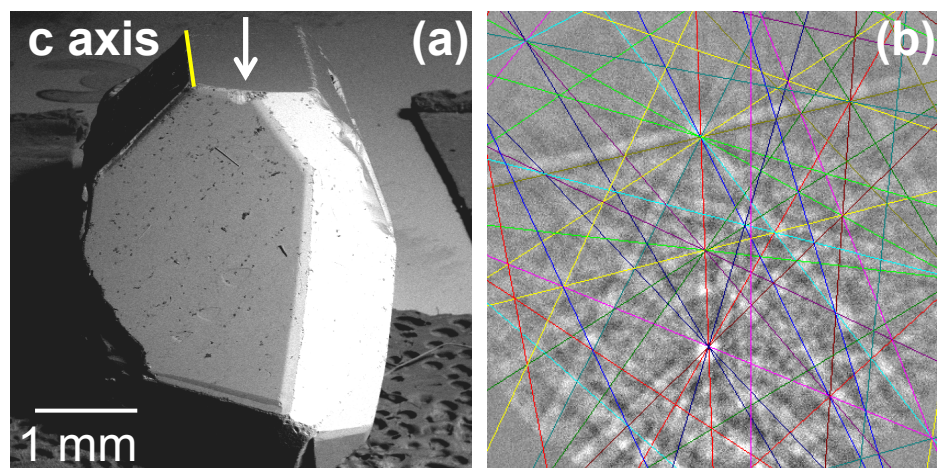
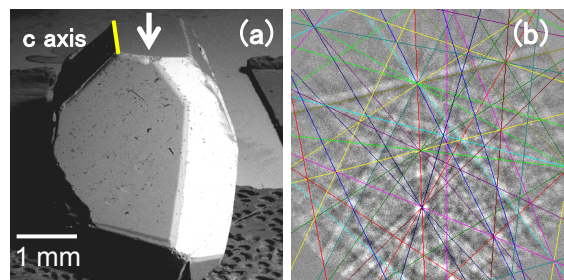


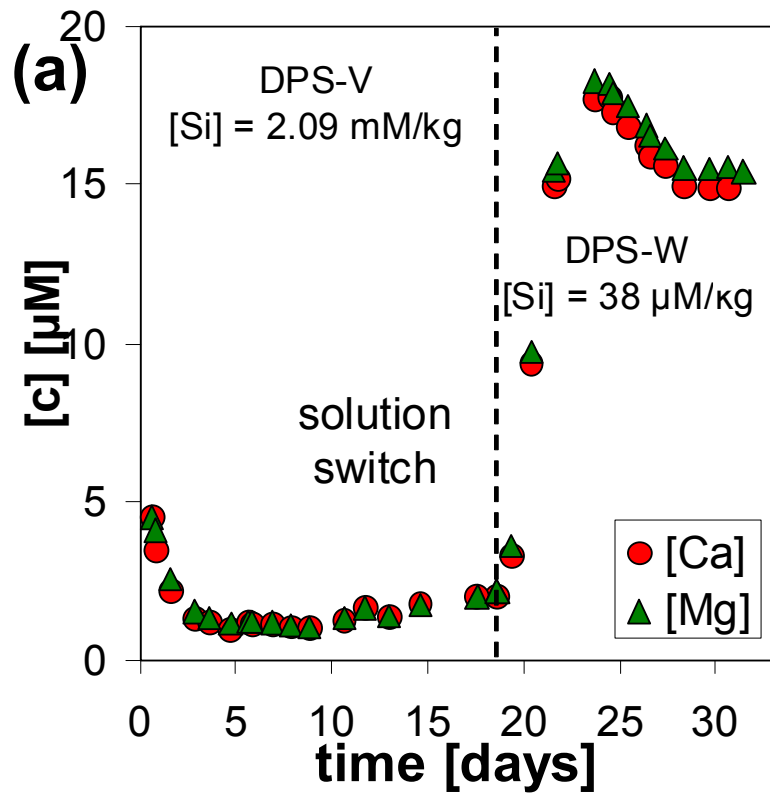
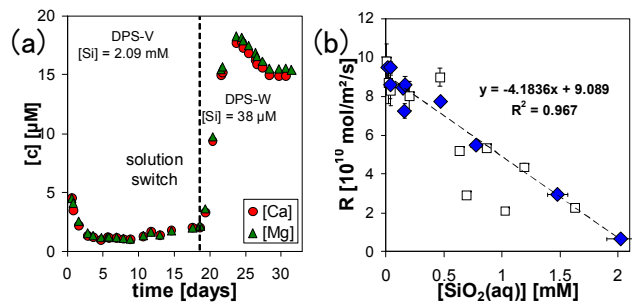
Figure 2

Figure 3

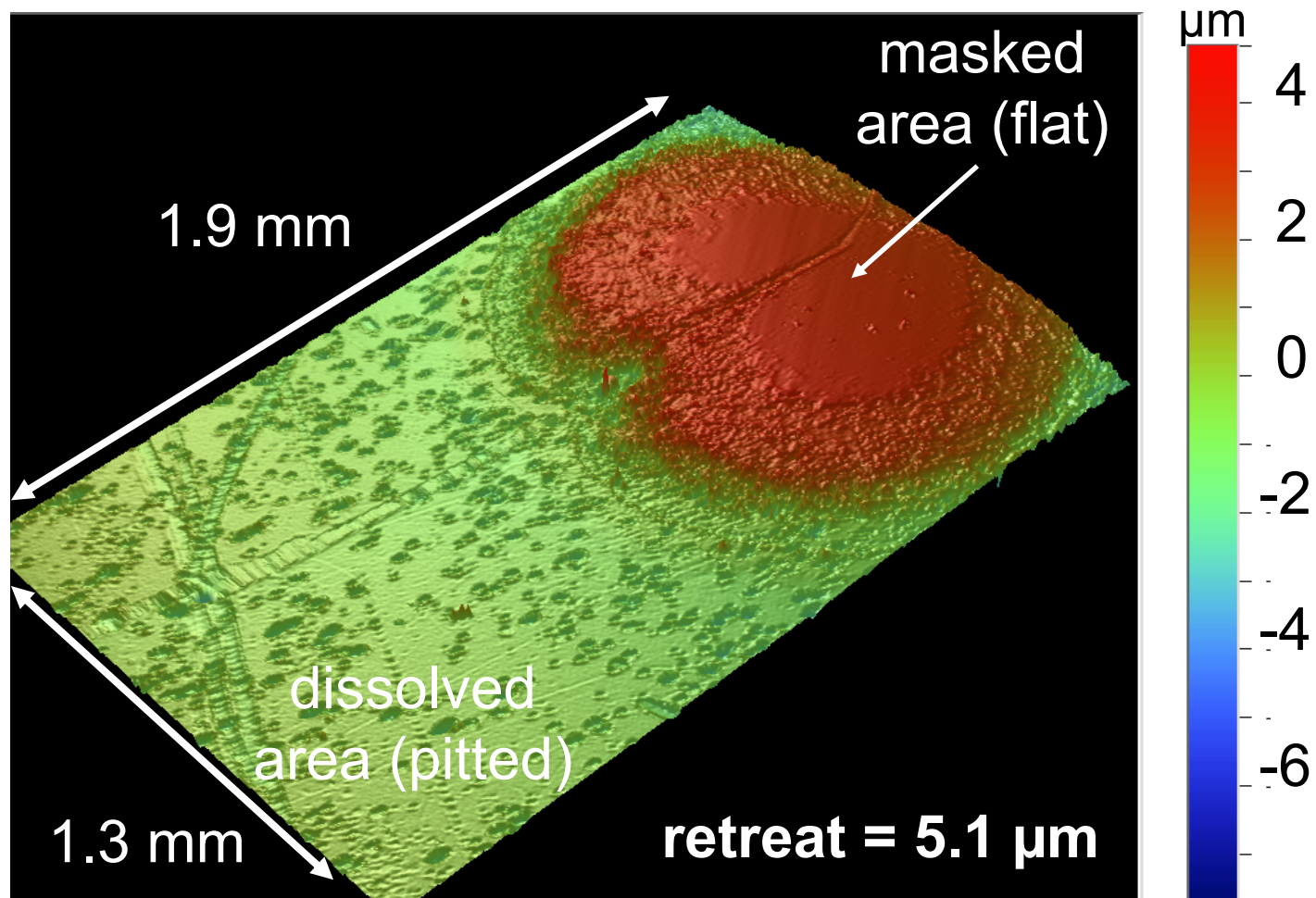
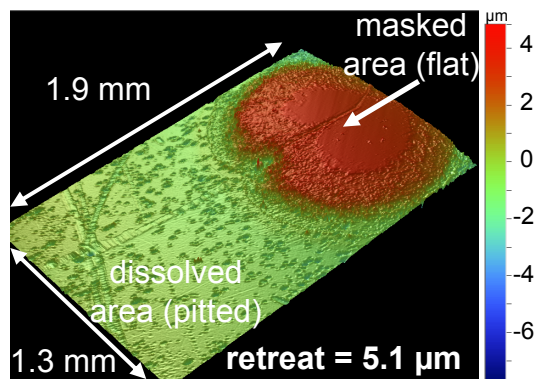


Figure 4

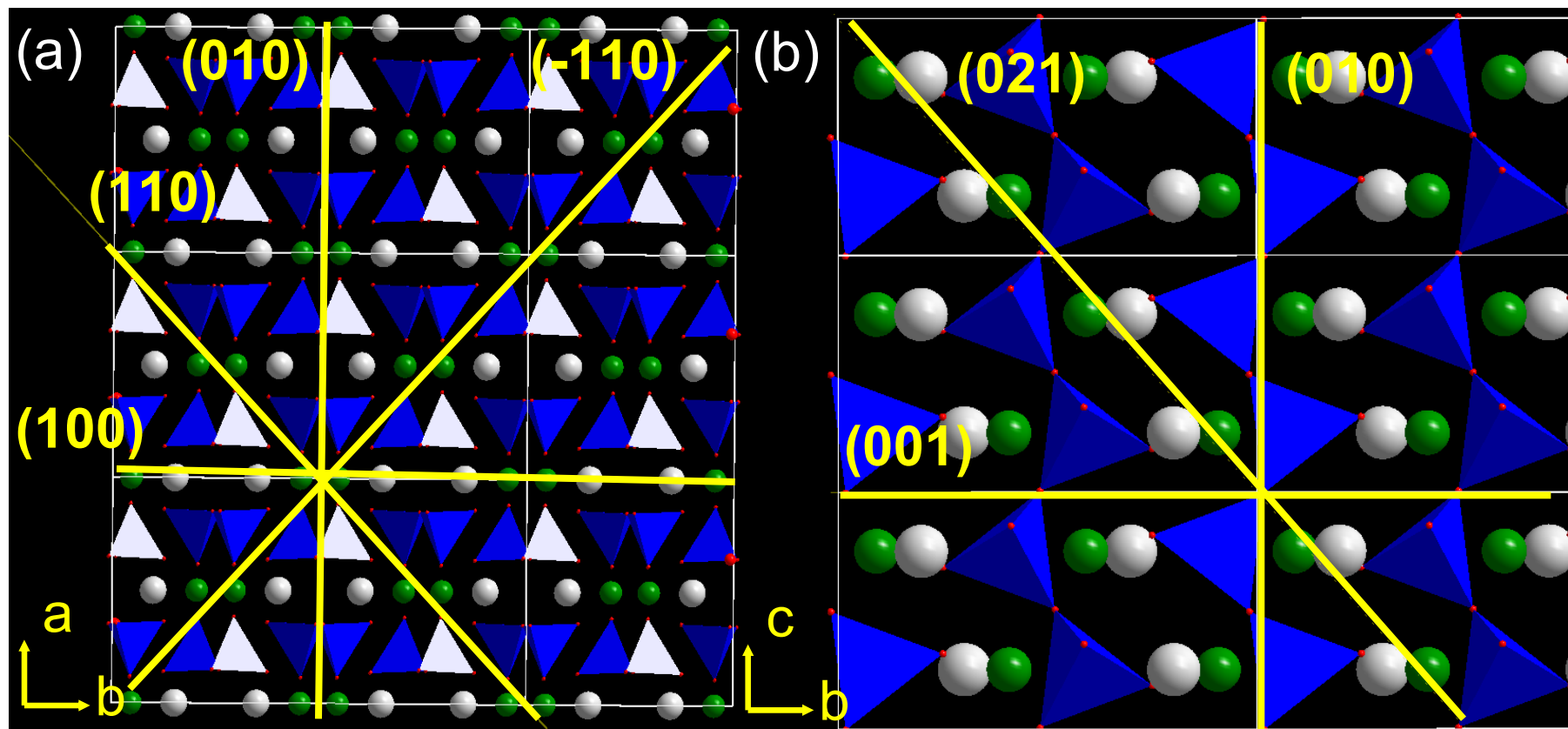
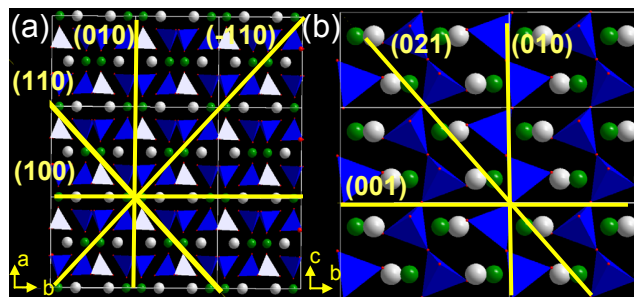


Figure 5

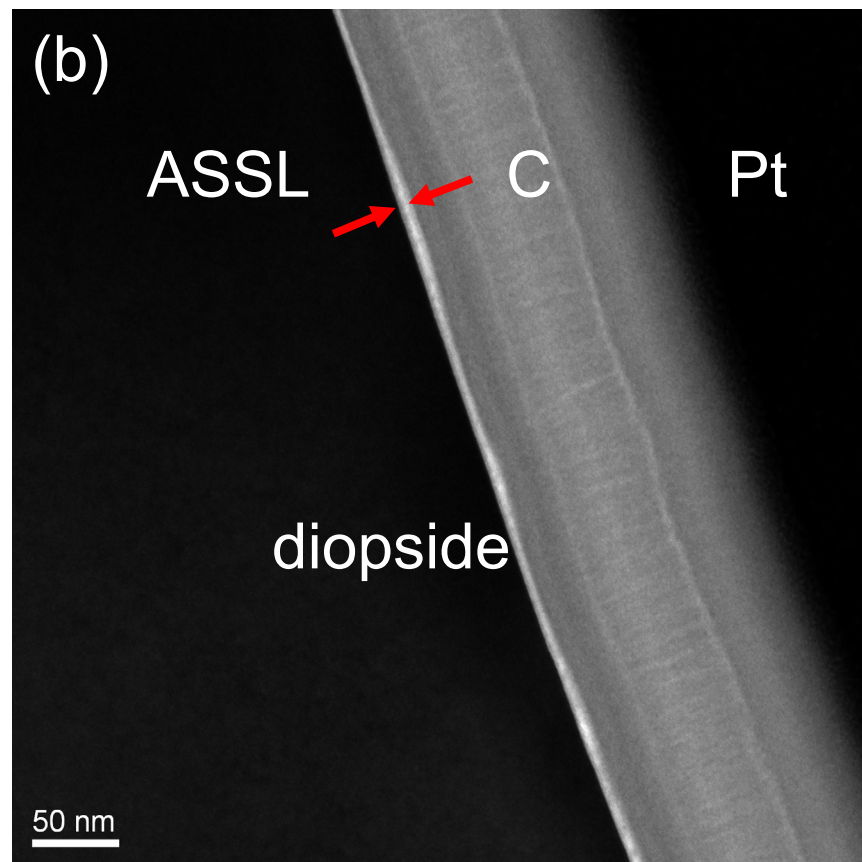
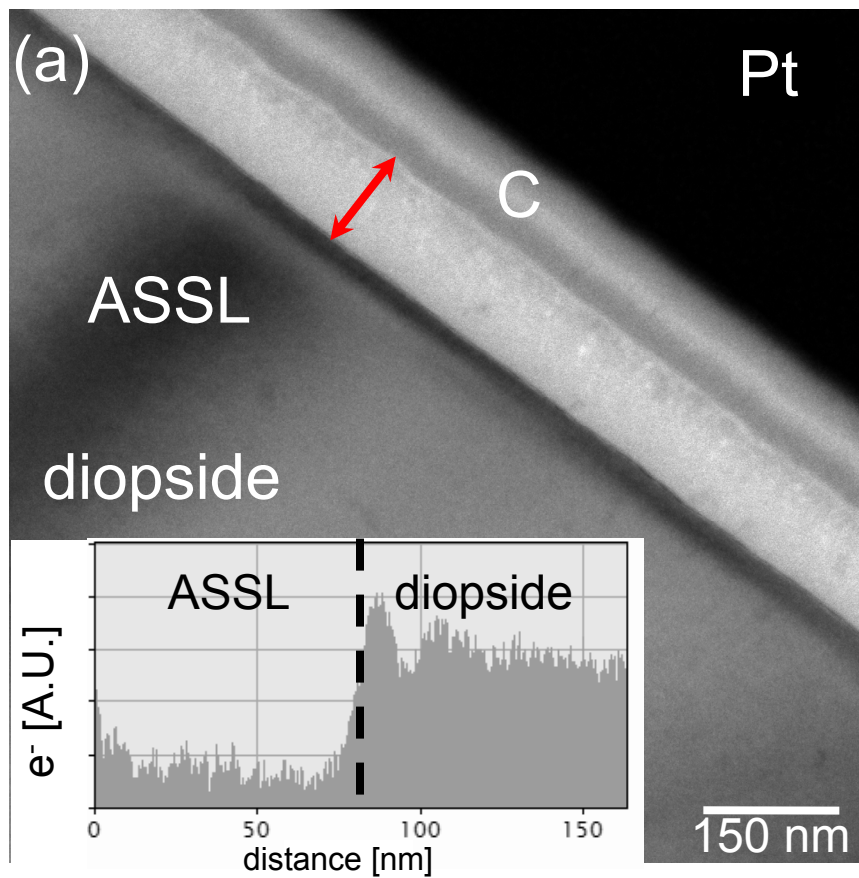
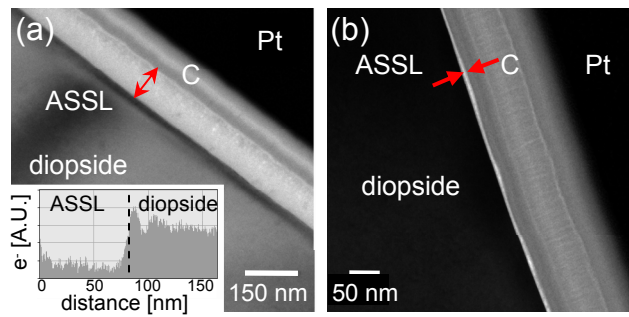


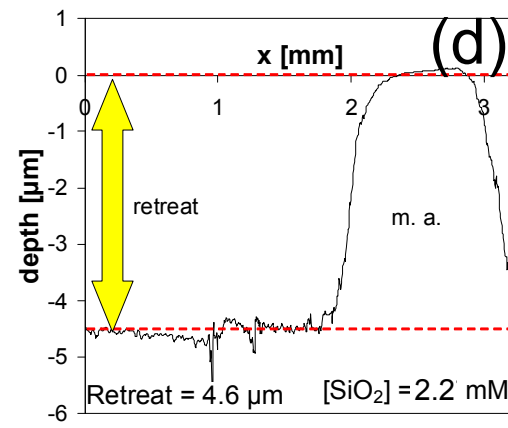
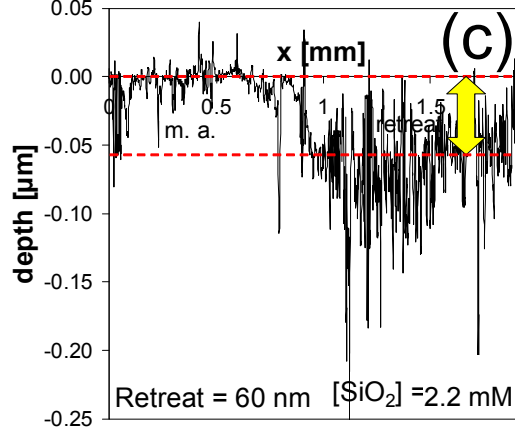
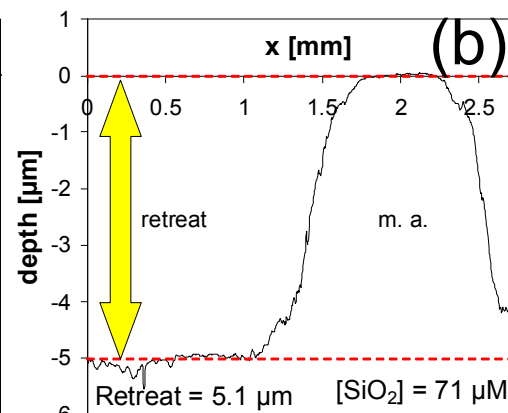
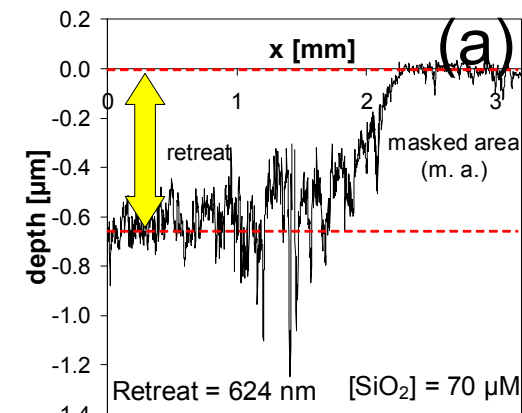
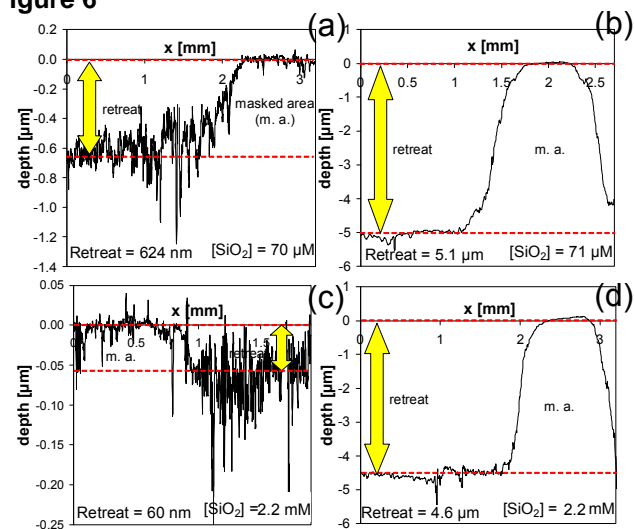
Figure 6

Figure 7

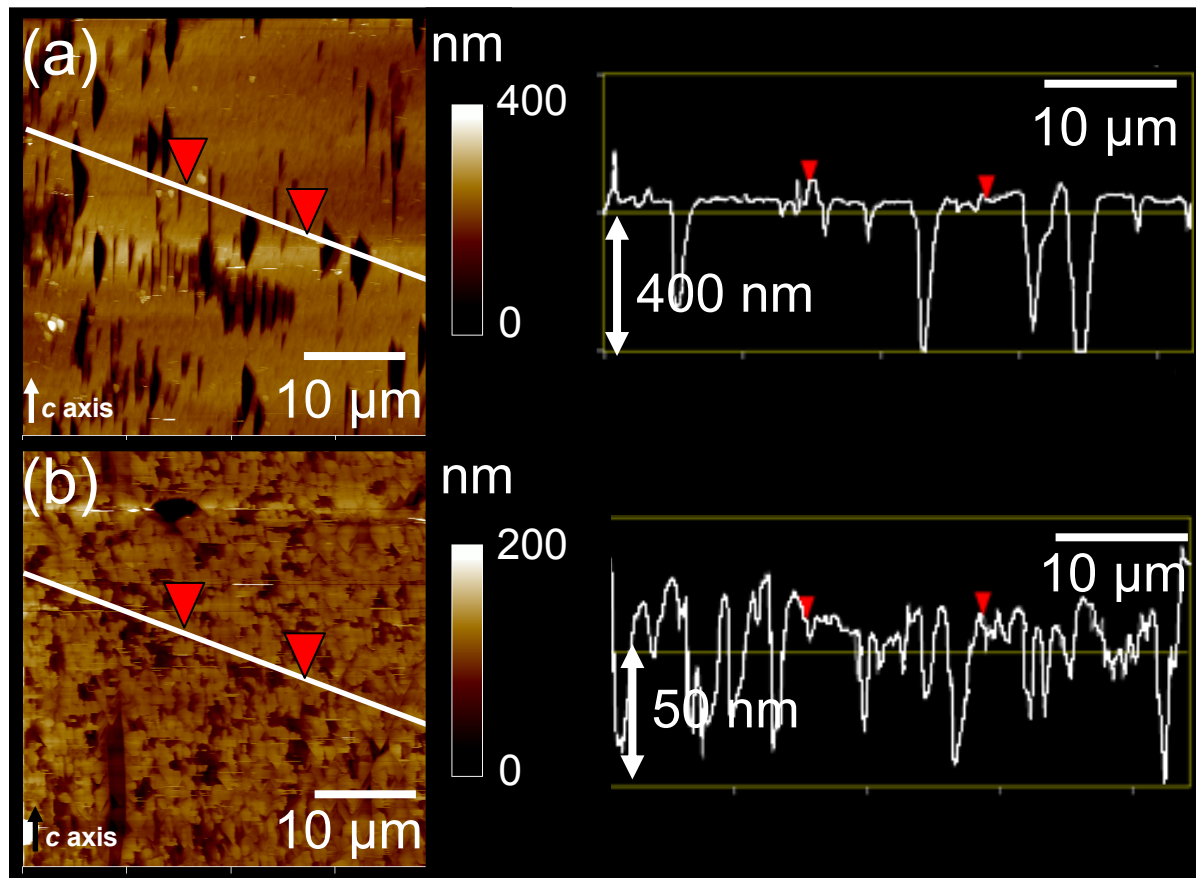
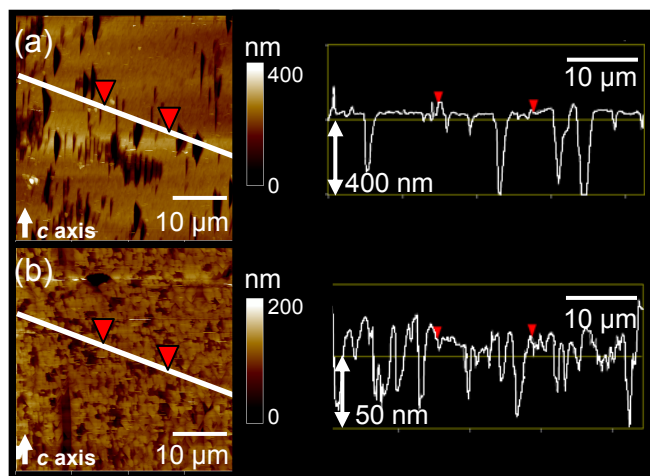
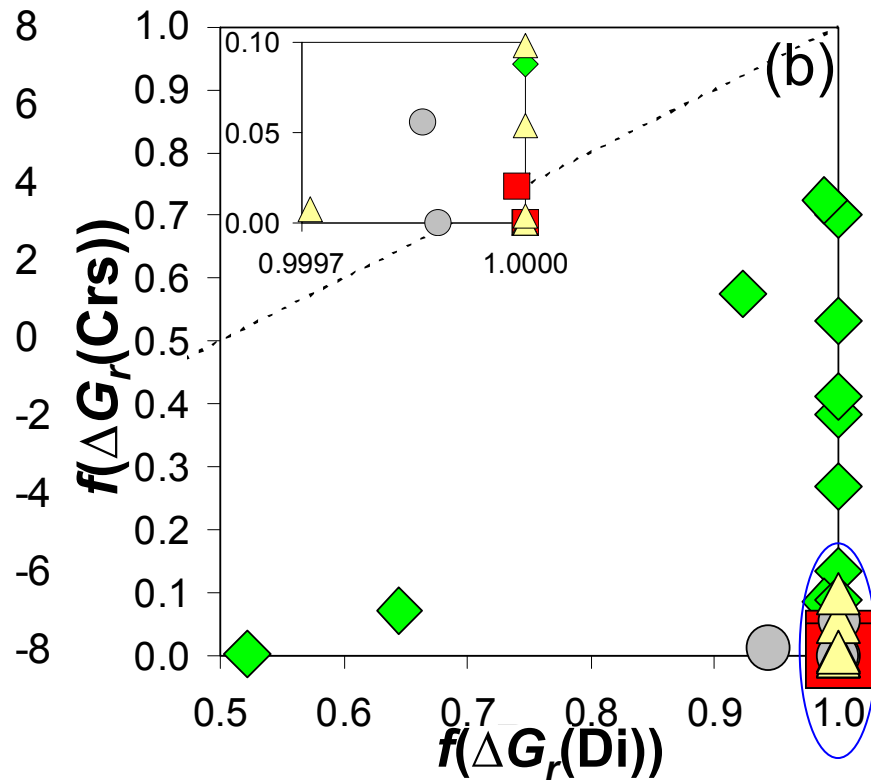
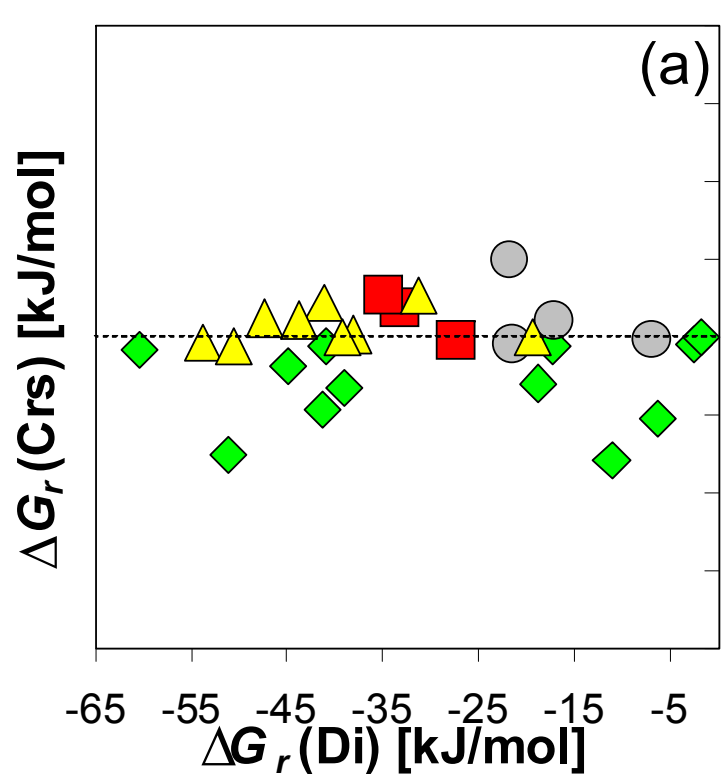
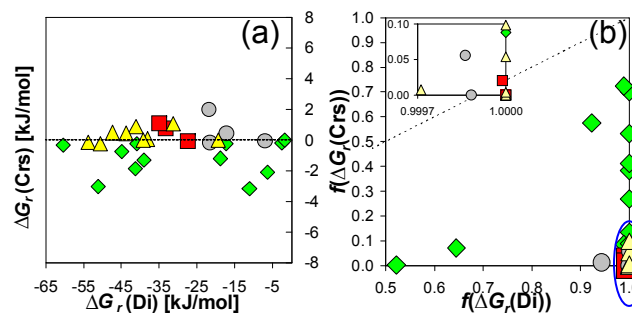
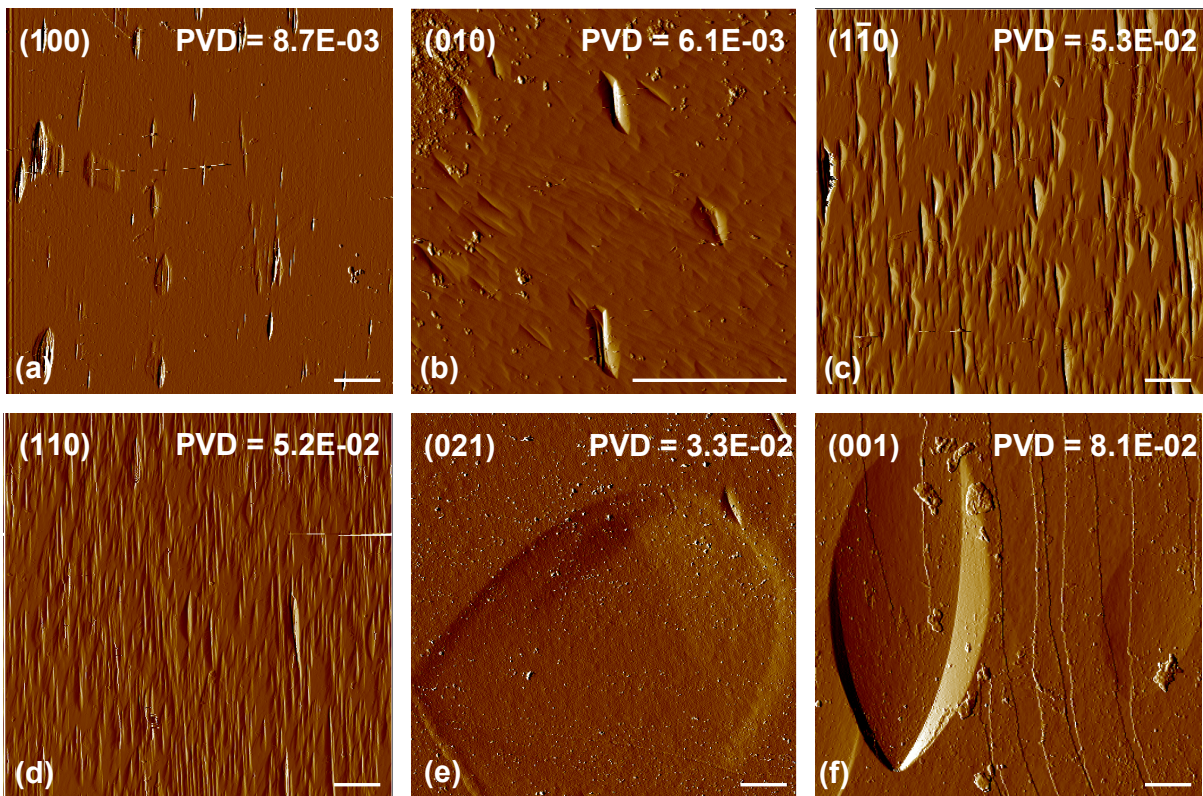


Figure 8



1 **Electronic Annex – Supporting information**

2 **Fig. EA1.** Typical deflection AFM images of diopside reacted in Si-free solutions for 30
3 days, shown in terms of increasing measured dissolution rates. For each face, a typical pit-
4 volume density ($PVD_{\text{low-Si}}^{(hkl)}$ [$\mu\text{m}^3/\mu\text{m}^2$]) was calculated by cumulating the volume of pits (μm^3)
5 on a given surface area of diopside (μm^2) (averaged over 3 to 6 different images from
6 different locations on the surface). The resulting PVD is reported at the top right corner of
7 each image; note that the PVD is a convolution of pit density and dimensions. The scale bar in
8 each image represents a distance of 10 μm .

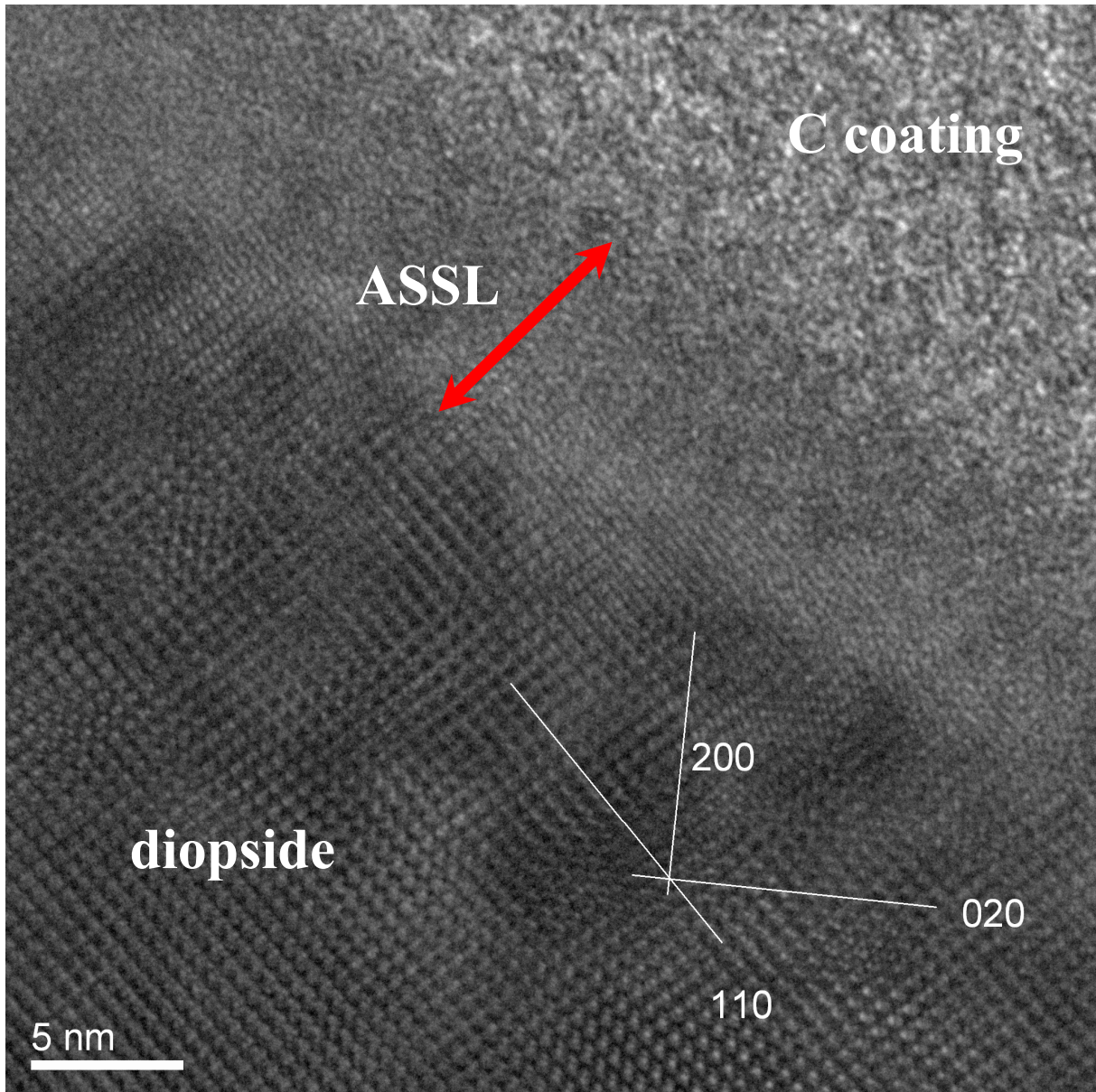


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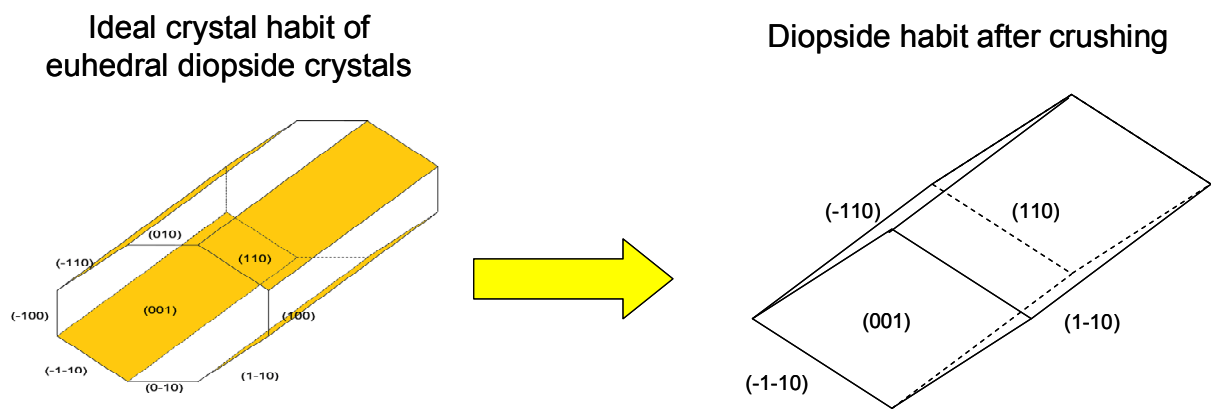
12 **Fig. EA2.** HRTEM image of the fluid/diopside interface realized on a FIB-prepared ultrathin
13 section perpendicular to the (110) face after chemical weathering in a Si-rich solution. An
14 amorphous silica rich surface layer (ASSL) formed on the diopside surface, with a mean
15 thickness of ~8 nm. This thickness is equivalent to the ASSL thickness reported for the same
16 face in a Si-free solution.



17
18

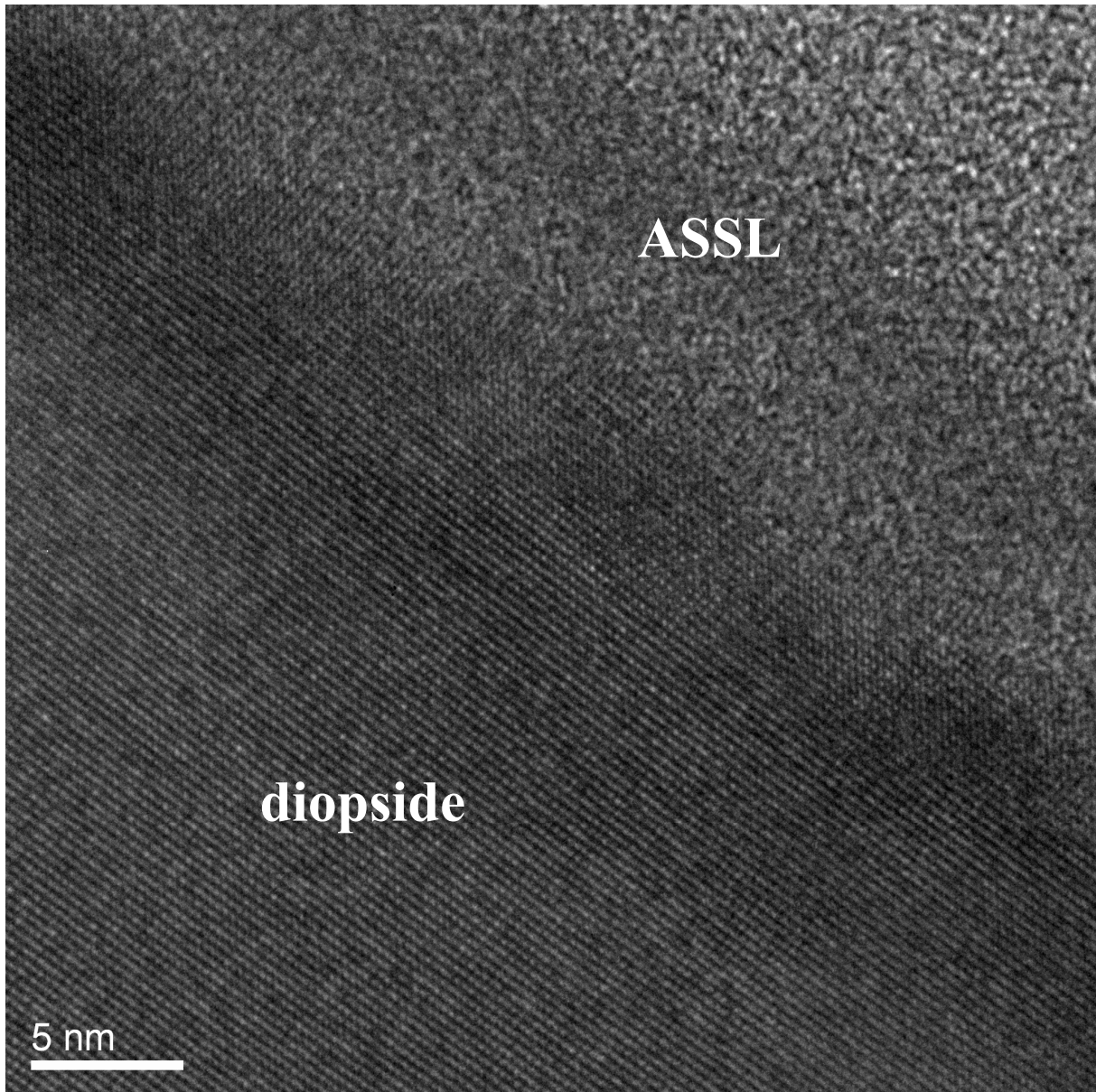
19 **Fig. EA3.** Representation of an “ideal” crystal habit of euhedral diopside, and of the expected
20 “ideal” morphology of crushed diopside crystals. Because (110) is the dominant cleavage
21 plane, one can expect that a diopside powder is mainly comprised of grains with (110) (and
22 equivalent $(\bar{1}\bar{1}0)$, $(\bar{1}\bar{1}0)$ and $(\bar{1}\bar{1}0)$) planes. Because diopside is an inosilicate with silicate
23 chains paralleling the c axis, crystals are often elongated in this direction, with a minor
24 contribution of $(hkl \neq 0)$ faces to the total surface area of a grain.

25



38 **Fig. EA4.** HRTEM image of the fluid/diopside interface realized on a FIB-prepared ultrathin
39 section perpendicular to the (021) face after chemical weathering in a Si-poor solution. The
40 amorphous nature of the surface layer is clearly visible.

41



42

43